

## PATENT COOPERATION TREATY

PCT

## NOTIFICATION OF ELECTION

(PCT Rule 61.2)

From the INTERNATIONAL BUREAU

To:

Assistant Commissioner for Patents  
 United States Patent and Trademark  
 Office  
 Box PCT  
 Washington, D.C. 20231  
 ETATS-UNIS D'AMERIQUE

in its capacity as elected Office

|  |  |
|--|--|
| Date of mailing (day/month/year)<br>01 May 2000 (01.05.00)                 | Applicant's or agent's file reference<br>P21403-P0             |
| International application No.<br>PCT/JP99/04961                            | Priority date (day/month/year)<br>14 September 1998 (14.09.98) |
| International filing date (day/month/year)<br>13 September 1999 (13.09.99) |  |
| Applicant<br>SASAKI, Yoshiki et al   |  |

1. The designated Office is hereby notified of its election made:

☒ in the demand filed with the International Preliminary Examining Authority on:  
20 March 2000 (20.03.00)

☐ in a notice effecting later election filed with the International Bureau on:

2. The election ☒ was  
☐ was not

made before the expiration of 19 months from the priority date or, where Rule 32 applies, within the time limit under Rule 32.2(b).

|   |                                  |
|---|----------------------------------|
| The International Bureau of WIPO<br>34, chemin des Colombettes<br>1211 Geneva 20, Switzerland | Authorized officer<br>R. Forax   |
| Facsimile No.: (41-22) 740.14.35  | Telephone No.: (41-22) 338.83.38 |



# PCT

## INTERNATIONAL SEARCH REPORT

(PCT Article 18 and Rules 43 and 44)

|   |   |  |
|---|---|--|
| Applicant's or agent's file reference<br><b>P21403-P0</b>           | <b>FOR FURTHER ACTION</b> see Notification of Transmittal of International Search Report (Form PCT/ISA/220) as well as, where applicable, item 5 below. |  |
| International application No.<br><b>PCT/JP 99/04961</b>             | International filing date (day/month/year)<br><b>13/09/1999</b>   | (Earliest) Priority Date (day/month/year)<br><b>14/09/1998</b> |
| Applicant<br><b>MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD. et al.</b> |   |  |

This International Search Report has been prepared by this International Searching Authority and is transmitted to the applicant according to Article 18. A copy is being transmitted to the International Bureau.

This International Search Report consists of a total of 3 sheets.

☒ It is also accompanied by a copy of each prior art document cited in this report.

### 1. Basis of the report

- a. With regard to the **language**, the international search was carried out on the basis of the international application in the language in which it was filed, unless otherwise indicated under this item.

☐ the international search was carried out on the basis of a translation of the international application furnished to this Authority (Rule 23.1(b)).

- b. With regard to any **nucleotide and/or amino acid sequence** disclosed in the international application, the international search was carried out on the basis of the sequence listing:

☐ contained in the international application in written form.

☐ filed together with the international application in computer readable form.

☐ furnished subsequently to this Authority in written form.

☐ furnished subsequently to this Authority in computer readable form.

☐ the statement that the subsequently furnished written sequence listing does not go beyond the disclosure in the international application as filed has been furnished.

☐ the statement that the information recorded in computer readable form is identical to the written sequence listing has been furnished.

2. ☐ **Certain claims were found unsearchable** (See Box I).

3. ☐ **Unity of invention is lacking** (see Box II).

4. With regard to the **title**,

☒ the text is approved as submitted by the applicant.

☐ the text has been established by this Authority to read as follows:

5. With regard to the **abstract**,

☒ the text is approved as submitted by the applicant.

☐ the text has been established, according to Rule 38.2(b), by this Authority as it appears in Box III. The applicant may, within one month from the date of mailing of this international search report, submit comments to this Authority.

6. The figure of the **drawings** to be published with the abstract is Figure No.

☒ as suggested by the applicant.

☐ because the applicant failed to suggest a figure.

☐ because this figure better characterizes the invention.

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☐ None of the figures.



## INTERNATIONAL SEARCH REPORT

International Application No

PCT/JP 99/04961

## A. CLASSIFICATION OF SUBJECT MATTER

IPC 7 H01J9/26 H01J9/38 H01J17/49

According to International Patent Classification (IPC) or to both national classification and IPC

## B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

IPC 7 H01J

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

## C. DOCUMENTS CONSIDERED TO BE RELEVANT

| Category * | Citation of document, with indication, where appropriate, of the relevant passages   | Relevant to claim No.                             |
|------------|--|---|
| X<br><br>A | WO 98 27571 A (AOKI MASAKI ;MURAI RYUICHI (JP); SUZUKI SHIGEO (JP); YASUI HIDEAKI)<br>25 June 1998 (1998-06-25)<br><br>& EP 0 945 886 A (MATSUSHITA ELECTRIC INDUSTRIAL CO LTD)<br>29 September 1999 (1999-09-29)<br>column 12, line 35 -column 13, line 42;<br>figure 1<br>column 20, line 36 -column 23, line 31;<br>figures 8-11<br>--- | 1-4, 32,<br>46-49,<br>54, 55<br>36, 39,<br>44, 45 |
| A          | EP 0 451 362 A (MITSUBISHI ELECTRIC CORP)<br>16 October 1991 (1991-10-16)<br><br>column 5, line 1 -column 7, line 14;<br>figures<br>---<br>-/--  | 1, 36, 45,<br>46, 48,<br>49, 55                   |

☒ Further documents are listed in the continuation of box C.☒ Patent family members are listed in annex.

## \* Special categories of cited documents:

- "A" document defining the general state of the art which is not considered to be of particular relevance
- "E" earlier document but published on or after the international filing date
- "L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)
- "O" document referring to an oral disclosure, use, exhibition or other means
- "P" document published prior to the international filing date but later than the priority date claimed

- "T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention
- "X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone
- "Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art
- "&" document member of the same patent family

Date of the actual completion of the international search

24 January 2000

Date of mailing of the international search report

01/02/2000

Name and mailing address of the ISA

European Patent Office, P.B. 5818 Patentlaan 2  
NL - 2280 HV Rijswijk  
Tel. (+31-70) 340-2040, Tx. 31 651 epo nl,  
Fax: (+31-70) 340-3016

Authorized officer

Schaub, G



## INTERNATIONAL SEARCH REPORT

International Application No.

PCT/JP 99/04961

## C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

| Category * | Citation of document, with indication, where appropriate, of the relevant passages        | Relevant to claim No. |
|------------|---|-----------------------|
| A          | US 5 754 003 A (MORI SHIGEO ET AL)<br>19 May 1998 (1998-05-19)<br>abstract; figures ----- | 1, 32, 36,<br>39, 44  |





# INTERNATIONAL SEARCH REPORT

Information on patent family members

International Application No

PCT/JP 99/04961

| Patent document<br>cited in search report |   | Publication<br>date | Patent family<br>member(s) |            | Publication<br>date |
|---|---|---------------------|----------------------------|------------|---------------------|
| WO 9827571                                | A | 25-06-1998          | EP                         | 0945886 A  | 29-09-1999          |
|   |   |                     | JP                         | 11204040 A | 30-07-1999          |
| EP 0451362                                | A | 16-10-1991          | JP                         | 2637272 B  | 06-08-1997          |
|   |   |                     | JP                         | 4002030 A  | 07-01-1992          |
|   |   |                     | US                         | 5207607 A  | 04-05-1993          |
| US 5754003                                | A | 19-05-1998          | JP                         | 8185802 A  | 16-07-1996          |



## PCT REQUEST

1/6

Original (for SUBMISSION) - printed on 08.09.1999 05:40:56 PM

P21403-P0

|         |   |   |
|---------|---|---|
| 0       | For receiving Office use only   |   |
| 0-1     | International Application No.   |   |
| 0-2     | International Filing Date   |   |
| 0-3     | Name of receiving Office and "PCT International Application"  |   |
| 0-4     | Form - PCT/RO/101 PCT Request Prepared using  | PCT-EASY Version 2.84<br>(updated 01.07.1999)                                       |
| 0-5     | Petition<br>The undersigned requests that the present international application be processed according to the Patent Cooperation Treaty |   |
| 0-6     | Receiving Office (specified by the applicant)   | Japanese Patent Office (RO/JP)  |
| 0-7     | Applicant's or agent's file reference   | P21403-P0   |
| I       | Title of Invention  | SEALING METHOD AND APPARATUS FOR MANUFACTURING HIGH-PERFORMANCE GAS DISCHARGE PANEL |
| II      | Applicant   | applicant only  |
| II-1    | This person is:   | all designated States except US   |
| II-2    | Applicant for   | MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD.  |
| II-4    | Name  | 1006, OazaKadoma,   |
| II-5    | Address:  | Kadoma-shi, Osaka 571-8501  |
| II-6    | State of nationality  | Japan   |
| II-7    | State of residence  | JP  |
| II-8    | Telephone No.   | JP  |
| II-9    | Facsimile No.   | 06-6908-5831  |
|         |   | 06-6906-8766  |
| III-1   | Applicant and/or Inventor   | applicant and inventor  |
| III-1-1 | This person is:   | US only   |
| III-1-2 | Applicant for   | SASAKI, Yoshiki   |
| III-1-4 | Name (LAST, First)  | 222-9, OoazaOkayama,  |
| III-1-5 | Address:  | Shijounawate-shi, Osaka 575-0004  |
| III-1-6 | State of nationality  | Japan   |
| III-1-7 | State of residence  | JP  |
|         |   | JP  |



## PCT REQUEST

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P21403-P0

|         |                           |   |
|---------|---------------------------|---|
| III-2   | Applicant and/or Inventor | applicant and inventor<br>US only<br>NONOMURA, Kinzou<br>3-1-5, Mayumi,<br>Ikoma-shi, Nara 630-0122<br>Japan<br>JP                      |
| III-2-1 | This person is:           |   |
| III-2-2 | Applicant for             |   |
| III-2-4 | Name (LAST, First)        |   |
| III-2-5 | Address:                  |   |
| III-2-6 | State of nationality      | JP  |
| III-2-7 | State of residence        | JP  |
| III-3   | Applicant and/or Inventor | applicant and inventor<br>US only<br>HIBINO, Junichi<br>919-1-A712, Utiage<br>Neyagawa-shi, Osaka 572-0802<br>Japan<br>JP               |
| III-3-1 | This person is:           |   |
| III-3-2 | Applicant for             |   |
| III-3-4 | Name (LAST, First)        |   |
| III-3-5 | Address:                  |   |
| III-3-6 | State of nationality      | JP  |
| III-3-7 | State of residence        | JP  |
| III-4   | Applicant and/or Inventor | applicant and inventor<br>US only<br>YONEHARA, Hiroyuki<br>9-10, Nishitamiyacho,<br>Hirakata-shi, Osaka 573-0025<br>Japan<br>JP         |
| III-4-1 | This person is:           |   |
| III-4-2 | Applicant for             |   |
| III-4-4 | Name (LAST, First)        |   |
| III-4-5 | Address:                  |   |
| III-4-6 | State of nationality      | JP  |
| III-4-7 | State of residence        | JP  |
| III-5   | Applicant and/or Inventor | applicant and inventor<br>US only<br>YAMASHITA, Katuyoshi<br>5-7-206, Myoukenzaka,<br>Katano-shi, Osaka 576-0021<br>Japan<br>JP         |
| III-5-1 | This person is:           |   |
| III-5-2 | Applicant for             |   |
| III-5-4 | Name (LAST, First)        |   |
| III-5-5 | Address:                  |   |
| III-5-6 | State of nationality      | JP  |
| III-5-7 | State of residence        | JP  |
| III-6   | Applicant and/or Inventor | applicant and inventor<br>US only<br>KIRIHARA, Nobuyuki<br>57-6, Nagaonishimachi 2-chome<br>Hirakata-shi, Osaka 573-0162<br>Japan<br>JP |
| III-6-1 | This person is:           |   |
| III-6-2 | Applicant for             |   |
| III-6-4 | Name (LAST, First)        |   |
| III-6-5 | Address:                  |   |
| III-6-6 | State of nationality      | JP  |
| III-6-7 | State of residence        | JP  |



## PCT REQUEST

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P21403-P0

|         |   |   |
|---------|---|---|
| III-7   | Applicant and/or Inventor   | <b>applicant and inventor</b><br><b>US only</b><br><b>OOTANI, Kazuo</b><br><b>4-3-5, Eganosou</b><br><b>Habikino-shi, Osaka 583-0886</b><br><b>Japan</b><br><b>JP</b>   |
| III-7-1 | This person is:   |   |
| III-7-2 | Applicant for   |   |
| III-7-4 | Name (LAST, First)  |   |
| III-7-5 | Address:  |   |
| III-7-6 | State of nationality  | JP  |
| III-7-7 | State of residence  | JP  |
| III-8   | Applicant and/or Inventor   | <b>applicant and inventor</b><br><b>US only</b><br><b>OOKAWA, Masafumi</b><br><b>Room303,</b><br><b>Syoufuuryou, 3-14, Miyukihigashimachi,</b><br><b>Neyagawa-shi, Osaka 572-0055</b><br><b>Japan</b><br><b>JP</b>  |
| III-8-1 | This person is:   |   |
| III-8-2 | Applicant for   |   |
| III-8-4 | Name (LAST, First)  |   |
| III-8-5 | Address:  |   |
| III-8-6 | State of nationality  | JP  |
| III-8-7 | State of residence  | JP  |
| IV-1    | Agent or common representative; or address for correspondence<br>The person identified below is hereby/has been appointed to act on behalf of the applicant(s) before the competent International Authorities as: | <b>agent</b><br><br><b>NAKAJIMA, Shiro</b><br><b>6F,</b><br><b>Yodogawa 5-Bankan, 2-1, Toyosaki</b><br><b>3-chome, Kita-ku,</b><br><b>Osaka-shi, Osaka 531-0072</b><br><b>Japan</b><br><b>06-6373-3246</b><br><b>06-6373-3105</b><br><b>nakapate@cap.bekkoame.or.jp</b> |
| IV-1-1  | Name (LAST, First)  |   |
| IV-1-2  | Address:  |   |
| IV-1-3  | Telephone No.   |   |
| IV-1-4  | Facsimile No.   |   |
| IV-1-5  | e-mail  |   |
| V       | Designation of States   |   |
| V-1     | Regional Patent<br>(other kinds of protection or treatment, if any, are specified between parentheses after the designation(s) concerned)   | EP: DE FR GB  |
| V-2     | National Patent<br>(other kinds of protection or treatment, if any, are specified between parentheses after the designation(s) concerned)   | CN KR US  |



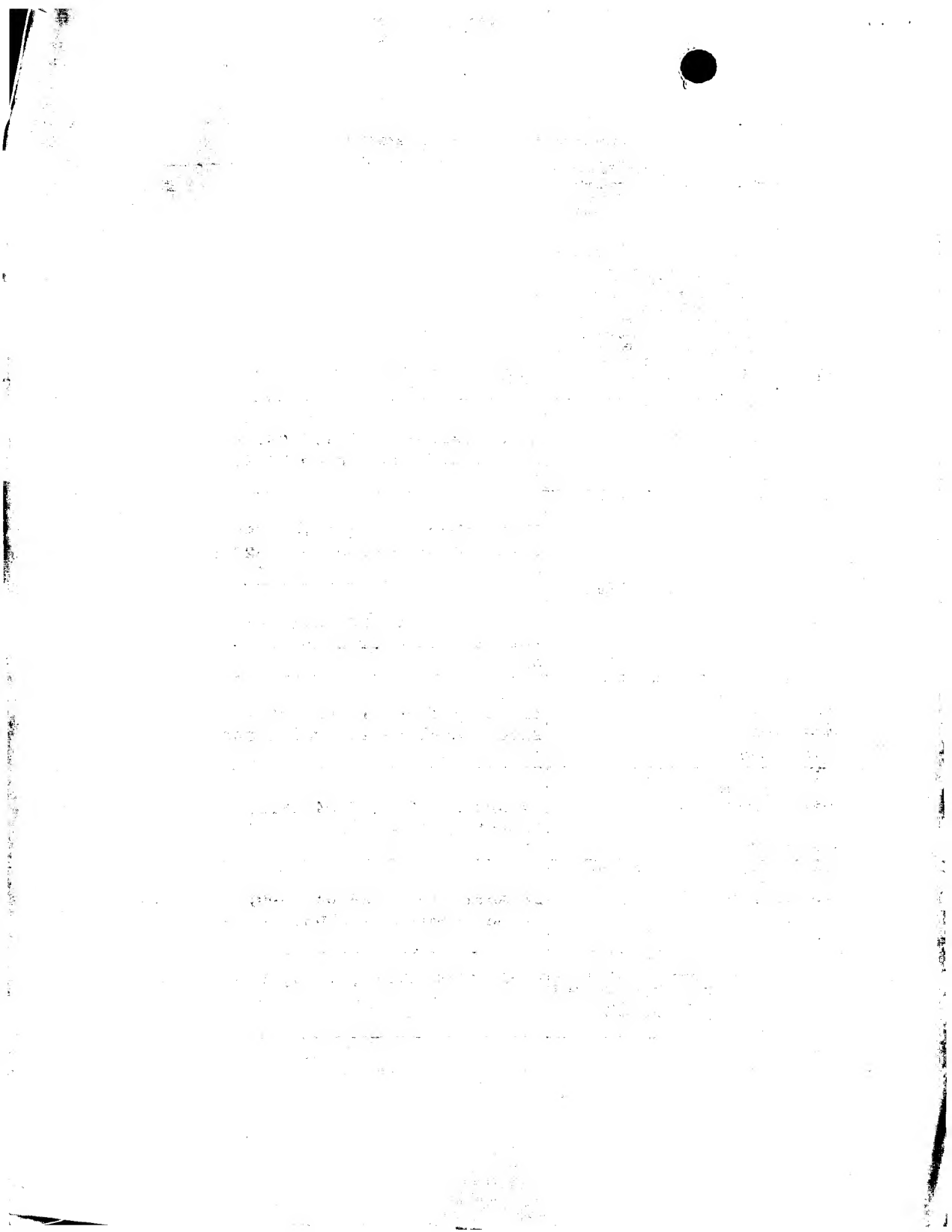


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|        |   |                                    |
|--------|---|------------------------------------|
| V-5    | <b>Precautionary Designation Statement</b><br>In addition to the designations made under items V-1, V-2 and V-3, the applicant also makes under Rule 4.9(b) all designations which would be permitted under the PCT except any designation(s) of the State(s) indicated under item V-6 below. The applicant declares that those additional designations are subject to confirmation and that any designation which is not confirmed before the expiration of 15 months from the priority date is to be regarded as withdrawn by the applicant at the expiration of that time limit. |                                    |
| V-6    | <b>Exclusion(s) from precautionary designations</b>   | NONE                               |
| VI-1   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-1-1 | Filing date   | 14 September 1998 (14.09.1998)     |
| VI-1-2 | Number  | Patent Application No.10-259880    |
| VI-1-3 | Country   | JP                                 |
| VI-2   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-2-1 | Filing date   | 16 October 1998 (16.10.1998)       |
| VI-2-2 | Number  | Patent Application No.10-294953    |
| VI-2-3 | Country   | JP                                 |
| VI-3   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-3-1 | Filing date   | 10 March 1999 (10.03.1999)         |
| VI-3-2 | Number  | Patent Application No.11-062765    |
| VI-3-3 | Country   | JP                                 |
| VI-4   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-4-1 | Filing date   | 12 March 1999 (12.03.1999)         |
| VI-4-2 | Number  | Patent Application No.11-066407    |
| VI-4-3 | Country   | JP                                 |
| VI-5   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-5-1 | Filing date   | 27 April 1999 (27.04.1999)         |
| VI-5-2 | Number  | Patent Application No.11-119446    |
| VI-5-3 | Country   | JP                                 |
| VI-6   | <b>Priority claim of earlier national application</b>   |                                    |
| VI-6-1 | Filing date   | 28 April 1999 (28.04.1999)         |
| VI-6-2 | Number  | Patent Application No.11-122106    |
| VI-6-3 | Country   | JP                                 |
| VI-7   | <b>Priority document request</b><br>The receiving Office is requested to prepare and transmit to the International Bureau a certified copy of the earlier application(s) identified above as item(s):   | VI-1, VI-2, VI-3, VI-4, VI-5, VI-6 |



## PCT REQUEST

P21403-P0

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|         |  |   |                             |
|---------|--|---|-----------------------------|
| VII-1   | International Searching Authority Chosen                   | European Patent Office (EPO) (ISA/EP)                   |                             |
| VIII    | Check list   | number of sheets  | electronic file(s) attached |
| VIII-1  | Request  | 6   | -                           |
| VIII-2  | Description  | 69  | -                           |
| VIII-3  | Claims   | 20  | -                           |
| VIII-4  | Abstract   | 1   | p21403-p0.txt               |
| VIII-5  | Drawings   | 29  | -                           |
| VIII-7  | TOTAL  | 125   |                             |
|         | Accompanying Items   | paper document(s) attached                              | electronic file(s) attached |
| VIII-8  | Fee calculation sheet                                      | ✓   | -                           |
| VIII-9  | Separate signed power of attorney                          | ✓   | -                           |
| VIII-10 | Copy of general power of attorney                          | ✓   | -                           |
| VIII-16 | PCT-EASY diskette  | -   | diskette                    |
| VIII-17 | Other (specified):   | Request for transmittal of priority document            | -                           |
| VIII-17 | Other (specified):   | Payment form bearing revenue stamps for appropriate fee | -                           |
| VIII-18 | Figure of the drawings which should accompany the abstract | 4   |                             |
| VIII-19 | Language of filing of the international application        | English   |                             |
| IX-1    | Signature of applicant or agent                            | <i>Shiro NAKAJIMA</i>                                   |                             |
| IX-1-1  | Name (LAST, First)   | NAKAJIMA, Shiro   |                             |

## FOR RECEIVING OFFICE USE ONLY

|        |   |        |
|--------|---|--------|
| 10-1   | Date of actual receipt of the purported international application   |        |
| 10-2   | Drawings:   |        |
| 10-2-1 | Received  |        |
| 10-2-2 | Not received  |        |
| 10-3   | Corrected date of actual receipt due to later but timely received papers or drawings completing the purported international application |        |
| 10-4   | Date of timely receipt of the required corrections under PCT Article 11(2)  |        |
| 10-5   | International Searching Authority   | ISA/EP |
| 10-6   | Transmittal of search copy delayed until search fee is paid   |        |



**PCT REQUEST**

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P21403-P0

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**FOR INTERNATIONAL BUREAU USE ONLY**

|      |   |  |
|------|---|--|
| 11-1 | Date of receipt of the record copy by<br>the International Bureau |  |
|------|---|--|



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PATENT COOPERATION TREATY

REC'D 22 JAN 2001

WIPO PCT

PCT

INTERNATIONAL PRELIMINARY EXAMINATION REPORT

(PCT Article 36 and Rule 70)



|  |  |  |  |
|--|--|--|--|
| Applicant's or agent's file reference<br>P21403-P0                                       |  | See Notification of Transmittal of International Preliminary Examination Report (Form PCT/PEA/416) |  |
| International application No.<br>PCT/JP99/04961  | International filing date (day/month/year)<br>13/09/1999 | Priority date (day/month/year)<br>14/09/1998   |  |
| International Patent Classification (IPC) or national classification and IPC<br>H01J9/26 |  |  |  |
| Applicant<br>MATSUSHITA ELECTRIC INDUSTRIAL CO., LTD. et al.                             |  |  |  |

- This international preliminary examination report has been prepared by this International Preliminary Examining Authority and is transmitted to the applicant according to Article 36.
- This REPORT consists of a total of 8 sheets, including this cover sheet.
  - ☐ This report is also accompanied by ANNEXES, i.e. sheets of the description, claims and/or drawings which have been amended and are the basis for this report and/or sheets containing rectifications made before this Authority (see Rule 70.16 and Section 607 of the Administrative Instructions under the PCT).

These annexes consist of a total of sheets.

- This report contains indications relating to the following items:

- I ☒ Basis of the report
- II ☐ Priority
- III ☐ Non-establishment of opinion with regard to novelty, inventive step and industrial applicability
- IV ☒ Lack of unity of invention
- V ☒ Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement
- VI ☐ Certain documents cited
- VII ☒ Certain defects in the international application
- VIII ☒ Certain observations on the international application

|   |  |
|---|--|
| Date of submission of the demand<br>20/03/2000  | Date of completion of this report<br>18.01.2001  |
| Name and mailing address of the international preliminary examining authority:<br> European Patent Office<br>D-80298 Munich<br>Tel. +49 89 2399 - 0 Tx: 523656 epmu d<br>Fax: +49 89 2399 - 4465 | Authorized officer<br>Chevrier, D<br>Telephone No. +49 89 2399 2819<br> |





# INTERNATIONAL PRELIMINARY EXAMINATION REPORT

International application No. PCT/JP99/04961

## I. Basis of the report

1. This report has been drawn on the basis of *(substitute sheets which have been furnished to the receiving Office in response to an invitation under Article 14 are referred to in this report as "originally filed" and are not annexed to the report since they do not contain amendments (Rules 70.16 and 70.17).):*

### Description, pages:

1-69 as originally filed

### Claims, No.:

1-59 as originally filed

### Drawings, sheets:

1/29-29/29 as originally filed

2. With regard to the **language**, all the elements marked above were available or furnished to this Authority in the language in which the international application was filed, unless otherwise indicated under this item.

These elements were available or furnished to this Authority in the following language: , which is:

- ☐ the language of a translation furnished for the purposes of the international search (under Rule 23.1(b)).
- ☐ the language of publication of the international application (under Rule 48.3(b)).
- ☐ the language of a translation furnished for the purposes of international preliminary examination (under Rule 55.2 and/or 55.3).

3. With regard to any **nucleotide and/or amino acid sequence** disclosed in the international application, the international preliminary examination was carried out on the basis of the sequence listing:

- ☐ contained in the international application in written form.
- ☐ filed together with the international application in computer readable form.
- ☐ furnished subsequently to this Authority in written form.
- ☐ furnished subsequently to this Authority in computer readable form.
- ☐ The statement that the subsequently furnished written sequence listing does not go beyond the disclosure in the international application as filed has been furnished.
- ☐ The statement that the information recorded in computer readable form is identical to the written sequence listing has been furnished.

4. The amendments have resulted in the cancellation of:

- ☐ the description, pages:
- ☐ the claims, Nos.:



# INTERNATIONAL PRELIMINARY EXAMINATION REPORT

International application No. PCT/JP99/04961

☐ the drawings, sheets:

5. ☐ This report has been established as if (some of) the amendments had not been made, since they have been considered to go beyond the disclosure as filed (Rule 70.2(c)):  
*(Any replacement sheet containing such amendments must be referred to under item 1 and annexed to this report.)*

6. Additional observations, if necessary:

## IV. Lack of unity of invention

1. In response to the invitation to restrict or pay additional fees the applicant has:

- ☐ restricted the claims.  
☒ paid additional fees.  
☐ paid additional fees under protest.  
☐ neither restricted nor paid additional fees.

2. ☐ This Authority found that the requirement of unity of invention is not complied and chose, according to Rule 68.1, not to invite the applicant to restrict or pay additional fees.

3. This Authority considers that the requirement of unity of invention in accordance with Rules 13.1, 13.2 and 13.3 is

- ☐ complied with.  
☒ not complied with for the following reasons:  
**see separate sheet**

4. Consequently, the following parts of the international application were the subject of international preliminary examination in establishing this report:

- ☒ all parts.  
☐ the parts relating to claims Nos. .

## V. Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

1. Statement

|                     |      |   |
|---------------------|------|---|
| Novelty (N)         | Yes: | Claims 5-31,33-35,37-38,40-43,50-52,56-59 |
|                     | No:  | Claims 1-4,32,36,39,44-49,53-55           |
| Inventive step (IS) | Yes: | Claims 49-52                              |
|                     | No:  | Claims 1-48,53-59                         |



# **INTERNATIONAL PRELIMINARY EXAMINATION REPORT**

International application No. PCT/JP99/04961

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Industrial applicability (IA)    Yes:    Claims    1-59  
   No:    Claims

2. Citations and explanations  
**see separate sheet**

## **VII. Certain defects in the international application**

The following defects in the form or contents of the international application have been noted:  
**see separate sheet**

## **VIII. Certain observations on the international application**

The following observations on the clarity of the claims, description, and drawings or on the question whether the claims are fully supported by the description, are made:  
**see separate sheet**



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**Lack of unity of invention (Item IV)**

- 1 The following separate groups of invention are not so linked as to form a single general inventive concept (Rule 13.1 PCT) for the following reasons:

(I) The gas discharge panel production method of claim 1 and the gas discharge panel bonding apparatus claim 55 concern the pressure adjustment inside the surrounding unit.

(II) The gas discharge panel of claim 54 and the gas discharge panel production methods of claims 36, 39, 44 and 45 concern the bonding of the top of the barrier ribs with the second panel.

(III) The gas discharge panel production method of claim 46 and the exhaust pipe sealing off apparatus of claims 48 and 49 concern the sealing off of an exhaust pipe.

**Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability: citations and explanations supporting such statement**  
**(Item V)**

- 2 Reference is made to the following documents:

D1: WO 9827571A (the relevant passages of this document will be given with reference to the corresponding document EP0945886 A)

D2: EP-A-0451362

D3: US-A-5754003

- 3 The present application does not meet the requirements of Article 33(2) PCT.

Claims 1 and 53

Document D1 discloses gas discharge panel production method (see Fig. 6 and corresponding text) comprising:





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a surrounding unit forming step for forming a surrounding unit (10) by putting a first panel (8) and a second panel (4) together, wherein barrier ribs (7) for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are put together to face each other with the barrier ribs in between; and a sealing step including sealing the surrounding unit with a sealing material (9) inserted between the first panel and the second panel at the rim, and adjusting the pressure inside the surrounding unit so that the pressure inside the surrounding unit is lower than the pressure outside the surrounding unit (see column 20, lines 2-24).

Claim 55 (see point 7 below)

The surrounding unit (10) illustrated by fig. 6 in document D1 is sealed by heating the sealing member (9) having a low melting point [in a housing unit with a sealing means] and the pressure inside the surrounding unit is adjusted [by a pressure adjustment means] so that the pressure is lower than the pressure outside the surrounding unit.

Claim 54

Document D1 (see Fig. 6 and corresponding text) discloses a gas discharge panel (10) including a first panel (8) and a second panel (4), wherein barrier ribs (7) for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are bonded together at the rim (9), the first panel and the second panel facing each other with the barrier ribs in between, wherein top of the barrier ribs and the second panel are bonded together by melting a material (15) of the barrier ribs.

Claim 36, 39, 44 and 45

Document D1 (see Fig. 6 and corresponding text, in particular column 19, lines 3-24) discloses a gas discharge panel production method in which the top of the barrier ribs (UV adhesive, frit glass, water glass or sealing material used in vacuum applications) are softened by radiating energy onto the top of the barrier ribs through the second panel.

Claim 46

Document D1 (see Fig. 6, 8, 9-11 and corresponding texts) discloses a gas



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discharge panel production method in which a heating element (17,18,14) disposed at a predetermined distance of the exhaust pipe (13) melts the exhaust pipe.

**Claim 48**

Document D1 (see Fig. 6, 8, 9-11 and corresponding texts) discloses a sealing off apparatus in which the holding means (17) with its heating element are attached to the exhaust pipe (13) for melting and sealing off the exhaust pipe of the surrounding unit.

The subject-matter of claims 1, 53, 55, 54, 36, 39, 44, 45, 46 and 48 not being new in view of the state of the art as defined by Rule 64(1)-(3) PCT, the present application does not meet the requirements of Article 33(2) PCT.

- 4 Dependent claims 2-35, 37-38, 40-43, 47, 56-59 disclose known (see documents D1-D3) and/or trivial additional features so that a combination of these claims with any claim to which they refer, would not meet the requirements of the PCT in respect of novelty and/or inventive step.

**Certain defects in the international application (form and content) (Item VII)**

- 5 Reference signs in parentheses should be provided to the technical features of the claims to the extent of all the corresponding reference signs as present in the drawings (see Rule 6.2(b) PCT). This applies to both the preamble and characterising portion (see the Guidelines, C-III, 4.11).  
When all the reference signs are provided to the technical features of the claims, the applicant should control that the same terminology is used in the independent claims for defining the same features (*Consistency*, Rule 10.2 PCT). In case of doubt, the terminology of the description should be used.
- 6 The independent claims should be drafted in the two-part form in accordance with Rule 6.3(b) PCT, with those features known in combination from the best prior art



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document being placed in the preamble (Rule 6.3(b)(i) PCT) and with the remaining features being included in the characterising part (Rule 6.3(b)(ii) PCT).

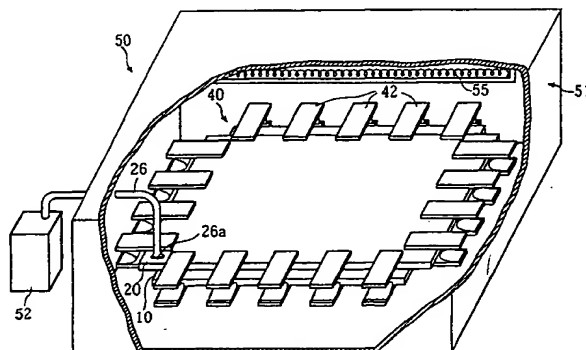
**Certain observations on the international application (clarity) (Item VIII)**

- 7 Claim 55 discloses a gas discharge panel bonding apparatus comprising a housing unit. The housing unit is suitable for housing a surrounding unit so that the features of the surrounding unit are not part of the claimed gas discharge panel bonding apparatus.
- 8 The requirement that the claims shall be concise (Art. 6 PCT) refers also to the number of claims which shall be reasonable in consideration of the nature of the invention claimed (see Rule 6.1(a) PCT and the Guidelines, C-III, 5). Moreover, subject to the conditions for unity of invention (Rule 13 PCT) being satisfied for each separate groups of invention (see point 1 above), an application may contain two or more independent claims in the same category **where it is not appropriate**, having regard to the subject-matter of the application, to cover this subject-matter by a single claim (see the Guidelines, C-III, 3.3).



## INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

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| (54) Title: SEALING METHOD AND APPARATUS FOR MANUFACTURING HIGH-PERFORMANCE GAS DISCHARGE PANEL  |  |   |   |



## (57) Abstract

A method is provided to steadily produce a gas discharge panel, such as a PDP, in which a panel and the top of the barrier ribs are in intimate contact in entirety. First a surrounding unit for the gas discharge panel is formed, then a process for sealing the surrounding unit with a sealing material inserted between two panels at the rim is performed while pressure is adjusted so that pressure inside the surrounding unit is lower than pressure outside. With this construction, the panels constituting the surrounding unit are bonded together while they are pressurized from outside. As a result, a panel and the top of the barrier ribs on the other panel are bonded together while they are in intimate contact in entirety. To fully acquire these effects, it is preferable that the adjustment of pressure starts before the sealing material hardens. During, before, or after the sealing step, an energy such as laser beams or ultrasonic waves may be radiated onto the top of the barrier ribs to bond a panel and the top of the barrier ribs in entirety almost without a gap between them.

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DESCRIPTIONSEALING METHOD AND APPARATUS FOR  
MANUFACTURING HIGH-PERFORMANCE GAS DISCHARGE PANELTECHNICAL FIELD

5 This invention relates to a method for producing a gas discharge panel, more specifically to a process for bonding a front panel and a back panel.

BACKGROUND ART

10 Recently, as the demand for high-quality large-screen TVs such as high definition TVs has increased, displays suitable for such TVs, such as Cathode Ray Tube (CRT), Liquid Crystal Display (LCD), and Plasma Display Panel (PDP), have been developed.

15 CRTs have been widely used as TV displays and excel in terms of resolution and picture quality. However, the depth and weight increase as the screen size increases. Therefore, CRTs are not suitable for large screen sizes exceeding 40 inch. LCDs consume a small amount of electricity and operate on a low voltage. However, producing a large LCD screen is technically  
20 difficult, and the viewing angles of LCDs are limited.

On the other hand, it is possible to make a PDP with a large screen with a short depth, and 50-inch PDP products have already been developed.

AC surface-discharge type PDP, a typical AC-type PDP, is typically composed of a front panel and a back panel to each of which electrodes are attached so that the electrodes of both panels face each other. A space between the front panel and the back panel is divided into a plurality of spaces by barrier ribs. The plurality of spaces between these barrier ribs are each filled with discharge gas and any of red, green, and blue fluorescent substances. When a driving circuit applies a voltage to each electrode to cause a discharge, ultraviolet light is emitted. The ultraviolet light excites fluorescent substances. The excited fluorescent substances emit red, green, and blue lights. The emitted light of these colors forms images on the screen.

Typically, such PDPs are manufactured by the following procedure. The barrier ribs are disposed on a surface of the back panel; fluorescent substance layers are formed in grooves between the barrier ribs; the front panel is laid on top of the barrier ribs to form a surrounding unit (the front panel and the back panel bonded together with inner space in between); the rim of the surrounding unit, that is, the front and back panels, is sealed with a sealing material; gas is exhausted from the inner space to produce a vacuum; and the inner space is filled with a

discharge gas.

The sealing material is typically a low-melting glass that softens by heat. A mixture of the low-melting glass and a binder is applied by a dispenser or the like to the rim of  
5 either the front panel or the back panel before the surrounding unit is constructed by putting the panels together. In the sealing process, the panels are bonded by heating the panels to a temperature higher than the softening point of the low-melting glass while the rim of the surrounding unit covering the applied  
10 sealing material and the outermost area is fixed by clips or the like.

However, the PDPs manufactured with such a method have gaps between the barrier ribs and the front panel. The gaps vary from barrier rib to barrier rib or from point to point on  
15 each barrier rib. The reason for this is considered as follows.  
(1) Variations of the barrier ribs in height are generated in the barrier rib formation process in which the material for the barrier ribs are placed on the back panel. (2) The panels and the barrier ribs are distorted in heating processes such as the  
20 processes for baking the barrier ribs, fluorescent substance, electrodes, and dielectric layer, and the sealing glass layer temporary baking process which are performed before the sealing process.

Further, in the sealing process of PDP, the rim of the  
25 front panel and the back panel is fixed by fastening tools such

as clips so as to prevent displacement of the panels after they were positioned to face each other. However, such fastening of the rim tends to generate a gap between the top of the barrier ribs and the front panel at the center by the action of a lever.

5 In addition, unequal gaps are often formed since the pressures given by the fastening tools are different.

In the PDPs manufactured through the sealing process with such gaps, crosstalks often occur when the PDPs are activated, or noises often occur between the barrier ribs and the panels due to vibration of the panels caused by the discharge or the like.

Japanese Utility Model Publication No. 1-113948 discloses a technique in which a low-melting glass is applied to the top of the barrier ribs before the front and back panels are positioned to face each other and bonded together. When the front panel is bonded with the whole top of the barrier ribs using this technique, the surrounding unit does not expand even if the inner space is filled with a discharge gas at high pressure. Also, the gaps between the barrier ribs and the front panel are filled with the sealing material. Accordingly, the technique solves the problem of the vibration.

However, in reality, it is difficult to bond the whole top of the barrier ribs with the front panel. A part of the top of the barrier ribs often remains unattached. Accordingly, this technique is not sufficient to solve the problem of the

pressure. Especially, when there are variations of the barrier ribs in height on the back panel, many parts remain unattached. When this happens, it is impossible to obtain sufficient resistance to pressure.

5           There is another conventional method in which a set of the front and back panels is heated for sealing while a weight such as a stone is placed at the center thereof. However, according to this method, more energy is required for the heating since the weight on the panels is also heated. The  
10 heating temperatures for surrounding units tends to be unequal. It is difficult to use this technique for the production of large-screen PDPs.

          There is another requirement for the production of the panels. Typically, a vacuum pump or a discharge gas cylinder is  
15 connected to an exhaust pipe attached to the surrounding unit. The exhaust pipe is chipped off later by a burner or a heater. A reliable method of chipping off the exhaust pipe is desired.

#### DISCLOSURE OF INVENTION

          It is an object of the present invention to provide  
20 a method of steadily producing a gas discharge panel, such as a PDP, in which a panel and the top of the barrier ribs are in intimate contact in entirety.

          To achieve the above object, first a surrounding unit for the gas discharge panel is formed, then a process for

sealing the surrounding unit with a sealing material inserted between two panels at the rim is performed while pressure is adjusted so that pressure inside the surrounding unit is lower than pressure outside the surrounding unit.

5               With the above-stated construction, the panels constituting the surrounding unit are bonded together while they are pressurized from outside. As a result, a panel and the top of the barrier ribs on the other panel are bonded together while they are in intimate contact in entirety.

10              To acquire the above effects, it is preferable that the adjustment of pressure starts before the sealing material hardens.

The adjustment of pressure can be achieved with the following methods:

15   (1) A connection path which connects inside of the surrounding unit to outside of the surrounding unit is formed, and gas is exhausted from inside of the surrounding unit to outside of the surrounding unit via the connection path.

20   (2) A container whose inside is under a pressure lower than the pressure inside the surrounding unit is used to reduce the pressure inside the surrounding unit.

25   (3) The gas flow between inside and outside of the surrounding unit is interrupted; then the pressure inside the surrounding unit after the gas-flow interruption is adjusted to be lower than before the gas-flow interruption (more specifically,

temperature in the surrounding unit is decreased, or the gas adsorption action of a gas adsorption member is used).

(4) The pressure outside the surrounding unit after the sealing of the rim of the surrounding unit is adjusted to be higher than  
5 before the sealing of the rim of the surrounding unit.

An adhesive may be applied to top of the barrier ribs on one panel before the surrounding unit is formed. The other panel and the top of the barrier ribs are bonded together by the adhesive while the rim of the surrounding unit is sealed by a  
10 sealing material. With such a construction, a panel and the top of the barrier ribs on the other panel are bonded together in entirety almost without a gap between them.

During or adjacent steps of the sealing step, an energy such as laser beams or ultrasonic waves may be radiated  
15 onto the top of the barrier ribs to bond a panel and the top of the barrier ribs. With this method, it is also possible to bond a panel and the top of the barrier ribs on the other panel together in entirety almost without a gap between them.

It is preferable that the sealing step is performed  
20 while the panels are pressurized by fastening tools pinching the panels so that the sealing process is more ensured. In this case, it is further preferable that an anti-deformation member is disposed at a position where the panels are pressurized by the fastening tools so as to prevent the panels from deforming  
25 by pressure by the fastening tools.

It is also preferable that the sealing step is performed while the surrounding unit is provided with anti-displacement means for preventing the relative displacement of the panels. It is further preferable that an anti-sealing-  
5 material-inflow member is disposed at the rim of a panel so as to prevent the sealing material from flowing into an inner area of the surrounding unit.

To chip off the exhaust pipe with reliability and without difficulty: a heating element holding means may be  
10 attached to the exhaust pipe; the heating element holding means holds a heating element at a location a predetermined distance from the exhaust pipe; and the heating element is activated in this condition.

#### BRIEF DESCRIPTION OF DRAWINGS

15 FIG. 1 is a perspective view of the AC surface-discharge type PDP in Embodiment 1.

FIG. 2 shows a construction of a display apparatus which is composed of a PDP and a circuit block attached to the PDP.

20 FIG. 3 is a sectional view of the sealing apparatus used in the sealing process of Embodiment 1.

FIG. 4 is a perspective view of the sealing apparatus shown in FIG. 3.

FIGs. 5A and 5B show the sealing process of Embodiment



2.

FIGS. 6A and 6B show the sealing process of Embodiment

3.

FIG. 7 shows the sealing process of Embodiment 4.

5

FIG. 8 shows the sealing process of Embodiment 5.

FIGS. 9A and 9B show the sealing process of Embodiment

5.

FIG. 10 is a perspective view showing the sealing process of Embodiment 7.

10

FIGS. 11A, 11B, and 11C show a method of producing the low-inner-pressure container used in the sealing process of Embodiment 7.

FIG. 12 shows a belt-conveyor-type heating apparatus used in the sealing process of Embodiment 7.

15

FIGS. 13A, 13B, and 13C show changes of state in the sealing process of Embodiment 7.

FIG. 14 shows a belt-conveyor-type heating apparatus used in the sealing process of Embodiment 8.

FIG. 15 shows the sealing process in which the belt-conveyor-type heating apparatus shown in FIG. 14 is used.

20

FIGS. 16A, 16B, and 16C show the sealing process of Embodiment 9.

FIG. 17 shows a belt-conveyor-type heating apparatus used in Embodiment 10.

25

FIG. 18 shows the sealing process in which the belt-

conveyor-type heating apparatus shown in FIG. 17 is used.

FIG. 19 shows the sealing process of Embodiment 11.

FIGs. 20A, 20B, 20C, and 20D show the sealing process of Embodiment 12

5           FIGs. 21A to 21F are partial front views showing specific shapes of the anti-deformation rib used in Embodiment 12.

          FIGs. 22A, 22B, and 22C show the process of bonding the top of the barrier ribs to the front panel by radiating a  
10   laser beam in Embodiment 13.

          FIG. 23 is a perspective view showing a specific laser processing apparatus used in Embodiment 13.

          FIG. 24 shows an example of the laser processing apparatus used in Embodiment 13.

15           FIG. 25 is a perspective view showing an exhaust pipe sealing apparatus used in Embodiment 14.

          FIG. 26 is a sectional view of the exhaust pipe sealing apparatus shown in FIG. 25.

          FIG. 27 is a variation of the exhaust pipe sealing  
20   apparatus of Embodiment 14.

          FIG. 28 is a variation of the exhaust pipe sealing apparatus of Embodiment 14.

          FIG. 29 is a variation of the exhaust pipe sealing apparatus of Embodiment 14.

25           FIG. 30 is a variation of the exhaust pipe sealing

apparatus of Embodiment 14.

#### BEST MODE FOR CARRYING OUT THE INVENTION

<General Construction and Production Method of PDP>

FIG. 1 is a perspective view of the AC surface-discharge type PDP in the present embodiment. FIG. 2 shows a construction of a display apparatus which is composed of a PDP and a circuit block attached to the PDP.

The PDP includes: a front panel 10 which is made up of a front glass substrate 11 with discharge electrodes 12 (divided into scanning electrodes 12a and sustaining electrodes 12b), a dielectric layer 13, and a protecting layer 14 formed thereon; and a back panel 20 which is made up of a back glass substrate 21 with address electrodes 22 and a dielectric layer 23 formed thereon. The front panel 10 and the back panel 20 are arranged so that the discharge electrodes 12 and the address electrodes 22 face each other with space in between.

The center area of the PDP is used for displaying images. At the center area, the space between the front panel 10 and the back panel 20 is divided into a plurality of discharge spaces 30 by barrier ribs 24 formed in stripes. Each discharge space is filled with a discharge gas. Fluorescent substance layers 25 are formed on the back panel 20 so that each discharge space 30 has a fluorescent substance layer of one color out of red, green, and blue. The fluorescent substance

layers are repeatedly arranged in the order of the colors.

In the panel, the discharge electrodes 12 and address electrodes 22 are respectively formed in stripes, the discharge electrodes 12 being perpendicular to the barrier ribs 24, and  
5 the address electrodes 22 being parallel to the barrier ribs 24.

A cell having one color out of red, green, and blue is formed at each intersection of a discharge electrode 12 and an address electrode 22.

10 The dielectric layer 13, being a layer composed of a dielectric material, covers the entire surface of one side of the front glass substrate 11 including the discharge electrodes 12. The dielectric layer is typically made of a low-softening-point glass containing lead as the main component, though it may  
15 be made of a low-softening-point glass containing bismuth as the main component or a stack of a low-softening-point glass containing lead as the main component and a low-softening-point glass containing bismuth as the main component.

The protecting layer 14 made of magnesium oxide (MgO)  
20 is a thin layer covering the entire surface of the dielectric layer 13. The dielectric layer 23 is mixed with  $\text{TiO}_2$  grains so that the layer also functions as a visible-light reflecting layer. The barrier ribs 24, which are made of glass material, are formed to project over the surface of the dielectric layer  
25 23 of the back panel 20.

The front panel 10 and the back panel 20 are bonded by a sealing material at the rim of the PDP.

The top of the barrier ribs 24 and the front panel 10 contact each other or are bonded together almost in entirety.

5 Now, a PDP production method is described.

#### Producing the front panel

The discharge electrodes 12 are formed on the front glass substrate 11. The dielectric layer 13 is then formed to cover the discharge electrodes 12. The front panel 10 is complete after the protecting layer 14 made of magnesium oxide (MgO) is formed on the dielectric layer 13 with the vacuum vapor deposition, electron-beam evaporation, or chemical vapor deposition.

The discharge electrodes 12 are formed by first applying a paste for silver electrode to the front glass substrate 11 with the screen printing method and then baking the applied paste. Alternatively, the discharge electrodes 12 may be formed first by forming transparent electrodes made of ITO (indium tin oxide) or SnO<sub>2</sub>, then forming silver electrodes as described above or forming Cr-Cu-Cr electrodes with the photolithography method, on the transparent electrodes.

The dielectric layer 13 is formed by applying a paste including a glass material containing lead as the main component (the composition is, for example, 70% by weight of lead oxide (PbO), 15% by weight of boron oxide (B<sub>2</sub>O<sub>3</sub>), and 15% by weight of

silicon oxide ( $\text{SiO}_2$ )) with the screen printing method, then baking the applied paste.

Producing the back panel

5 The address electrodes 22 are formed on the back glass substrate 21 in the same way as the discharge electrodes 12 by the screen printing method.

The dielectric layer 23 is then formed first by applying a glass material mixed with  $\text{TiO}_2$  grains and baking the applied material.

10 The barrier ribs 24 are then formed by recoating a paste for barrier ribs with the screen printing method and baking the coated paste. Alternatively, the barrier ribs 24 may be formed by applying a glass paste for barrier ribs to the entire surface of the back glass substrate 21 and trimming the  
15 paste with the sand blast method to leave the barrier ribs.

The fluorescent substance layers 25 are formed between the barrier ribs 24. Typically, the fluorescent substance layers 25 are formed by applying fluorescent substance pastes containing fluorescent substance grains for the three colors  
20 with the screen printing method and baking the applied pastes. Alternatively, the fluorescent substance layers 25 may be formed by moving a nozzle continuously ejecting a fluorescent substance ink along the barrier ribs to apply the ink to the grooves between the barrier ribs then baking the applied ink to remove  
25 solvents or binders from the ink. The fluorescent substance ink

of each color is a mixture of fluorescent substance grains of one color, a binder, a solvent, a dispersant, etc. adjusted to have a proper viscosity.

The following are specific examples of the fluorescent substances used in the present embodiment:

blue fluorescent substance  $\text{BaMgAl}_{10}\text{O}_{17} : \text{Eu}^{2+}$

green fluorescent substance  $\text{BaAl}_{12}\text{O}_{19} : \text{Mn}$ , or  $\text{Zn}_2\text{SiO}_4 : \text{Mn}$

red fluorescent substance  $(\text{Y}_x\text{Gd}_{1-x})\text{BO}_3 : \text{Eu}^{3+}$ , or  $\text{YBO}_3 : \text{Eu}^{3+}$

In the present embodiment, the height of the barrier ribs is set to 0.1-0.15mm, and the pitch of the barrier ribs to 0.15-0.36mm, conforming to 40-inch VGAs and high definition TVs.

#### 15 Sealing, Exhausting Gas, and Filling with Discharge Gas

The front panel and the back panel formed as described above are then bonded together.

In this sealing process, the front panel 10 and the back panel 20 are put together with a sealing material in between at their rims to form a surrounding unit. The panels are bonded together by the sealing material. Should the necessity arises, an adhesive is applied to the top of the barrier ribs 24 on the back panel 20 beforehand.

A material that softens by a given energy such as heat is used as the sealing material. Typically, a low-melting glass

is used as the sealing material. The panels with the low-melting glass is heated to a temperature higher than the softening point of the glass and is cooled so that the panels are bonded together by the cooled glass.

5           The panels are subjected to the sealing process while there is a difference between the pressures outside and inside the surrounding unit so that the panels 10 and 20 are given equal pressures from outside. This enables the panels to be bonded together while the top of the barrier ribs 24 and the  
10 front panel 10 are in contact or close to each other in entirety.

          After the sealing process, gas is exhausted from the inner space to produce a high vacuum (e.g.,  $8 \times 10^{-7}$  Torr) and exhaust impurities held by adsorption on the inside surface of  
15 the surrounding unit (Vacuum Exhaust Process).

          The inner space of the surrounding unit is then filled with a discharge gas (e.g., He-Ne or Ne-Xe inact gas) with a certain pressure (Discharge Gas Filling Process). The PDP is completed with this process.

20           In the present embodiment, Xe constitutes 5% in volume of the discharge gas, and the charging pressure for filling the discharge gas is in a range of 500-800Torr.

          The PDP is activated to display images by the circuit block which is attached to the PDP as shown in FIG. 2.

25           Embodiments 1 to 10 of the present invention are



described as follows in which the sealing, exhaust, and discharge gas filling processes are described in detail.

#### Embodiment 1

In the present embodiment, the sealing process is performed while gas is exhausted from the inner space of the surrounding unit with a vacuum pump.

FIG. 3 is a sectional view of the sealing apparatus 50 in the present embodiment. FIG. 4 is a perspective view of the sealing apparatus 50 shown in FIG. 3.

The sealing apparatus 50 is composed of: a furnace 51 for housing and heating the surrounding unit 40 which is the front panel 10 and the back panel 20 put together; and a vacuum pump 52 disposed at outside the furnace 51.

The furnace 51 is heated by a heater 55. It is possible to set the inner temperature of the furnace 51 to a desired degree with control.

The sealing process is performed using the sealing apparatus 50 as follows.

As shown in FIGs. 3 and 4, an air vent 21a is previously formed in the back panel 20 at the rim, outside the display area.

A paste mixed with the sealing material is applied to the rim of either of or both the front panel 10 and the back panel 20 on the surfaces facing each other. The applied paste is baked to form a sealing layer 41. In this example, a low-

melting glass which has a softening point lower than the barrier ribs 24 and the dielectric layer 23 is used as the sealing material.

For example, the low-melting glass paste includes 80%  
5 of a low-melting glass frit (softening point is 370°C), 5% of an ethyl cellulose binder, and 15% of isoamyl acetate. The sealing layer 41 can be formed by applying the paste using a dispenser.

The front panel 10 and the back panel 20 are  
10 positioned properly to face each other and are put together to form the surrounding unit 40. The rim of the surrounding unit 40 is fastened by clips 42 so that the panels are not displaced.

The surrounding unit 40 is set inside the furnace 51.  
15 A pipe 26 is attached to the air vent 21a of the surrounding unit 40 and the vacuum pump 52 to connect them. It is preferable that the pipe 26 is fixed to the back panel 20 by fastening tools such as clips (not illustrated).

In the present embodiment, the front panel 10 is  
20 positioned below the back panel 20 to facilitate the attachment of the pipe 26. However, the positions of the panels can be reversed. Also, the surrounding unit may be set vertically in the furnace so long as the panels 10 and 20 are fixed as firmly as not to be displaced.

25 The pipe 26 is made of a glass being resistant to the

sealing temperature. The pipe 26 extends upwards from the air vent 21a of the surrounding unit 40, bends at some midpoint, and extends and protrudes outside from the furnace 51 through a via hole 51a which is formed in the wall of the furnace 51. The  
5 pipe 26 bulges at the edge (referred to as connection edge) connecting to the air vent 21a, and the diameter of the connection edge is larger than that of the air vent 21a.

An adhesive 26a is inserted between the connection edge of the pipe 26 and the back panel 20 beforehand so that  
10 they are airtightly sealed. In the present embodiment, the same material is used for both the adhesive 26a and the sealing layer 41.

The end of the pipe 26 is connected to the vacuum pump  
52.

15 The inside of the furnace 51 is heated to the sealing temperature (e.g., 450°C) which is slightly higher than the softening point of the sealing material. The temperature of the inside of the furnace 51 is maintained at the sealing temperature for 10 to 30 minutes. The inside of the furnace 51  
20 is then cooled until the temperature is below the softening point of the sealing material. The panels 10 and 20 are bonded together by this process. During the sealing process, gas is exhausted from the surrounding unit 40 by the vacuum pump 52.

It is preferable that the above exhaust of gas is  
25 started after the inside of the furnace 51 has reached the

softening point of the sealing material. This is because the hermeticity at the rim between the panels 10 and 20 is not high until the inside of the furnace 51 reaches the softening point of the sealing material, and that once it reaches the softening point, the adhesive 26a softens to airtightly seal the pipe 26 and the air vent 21a, as well as the panels 10 and 20 at the rim. Accordingly, when gas is exhausted from the surrounding unit 40 after these parts are airtightly sealed, the pressure inside the surrounding unit 40 is reduced and a high vacuum (several Torr) is produced.

The panels 10 and 20 are equally pressurized from outside after gas is exhausted from the inner space of the surrounding unit 40. The exhaust of gas by the vacuum pump 52 is adjusted so that the pressure inside the surrounding unit 40 is reduced at a speed of about 5Torr per minute.

When the panels 10 and 20 are equally pressurized from outside, the top of the barrier ribs 24 on the back panel 20 and the front panel 10 are bonded together while they are in intimate contact in entirety, as shown in FIG. 3. When the inside of the furnace is cooled in this condition, the sealing material is also cooled to be below its softening point, resulting in the sealing of the surrounding unit 40. Accordingly, in the surrounding unit 40 after the sealing process, the top of the barrier ribs 24 and the front panel 10 are kept in absolute contact with one another in entirety.

The pipe 26 and the back panel 20 are also airtightly sealed by the hardened adhesive 26a.

The clips 42 are removed after the sealing of the surrounding unit 40 is complete and the next step, the vacuum exhaust process is performed.

In the vacuum exhaust process, the surrounding unit 40 is placed in a furnace for vacuum exhaust, a vacuum pump is connected to the pipe 26, the inside of the furnace is kept at an exhaust temperature (e.g., 350°C) which is slightly lower than the softening point of the sealing material, for a certain period (e.g., one hour).

In the next step, the discharge gas filling process, the discharge gas cylinder is connected to the pipe 26, and the discharge gas is supplied to the inner space of the surrounding unit 40 until the inner space is under the charging pressure (e.g., 400Torr). The air vent 21a is sealed when the base of the pipe 26 is melted by a burner or a heater to be chipped off (see Embodiment 14).

The above procedure may be replaced by another in which the surrounding unit 40 is subjected to the sealing process, vacuum exhaust process, and discharge gas filling process continuously in one heating apparatus. For example, in the sealing apparatus 50, a cylinder for supplying the discharge gas is prepared so that it can be connected to the pipe 26. Then, after the sealing process, the surrounding unit 40 is kept

to be set in the furnace 51. The furnace 51 is cooled to the exhaust temperature, then gas is exhausted from the surrounding unit by the vacuum pump 52. Furthermore, the cylinder can be connected to the pipe 26 for supplying the discharge gas.

5           The above procedure may further be replaced by another in which a continuous heating apparatus is used to perform the sealing process, vacuum exhaust process, and discharge gas filling process continuously. For example, the vacuum pump and the discharge gas cylinder, as well as the surrounding unit 40,  
10 are loaded on a cart that can move in a continuous furnace. It is possible that gas is exhausted from the surrounding unit by the vacuum pump and the surrounding unit is filled with the discharge gas by the discharge gas cylinder while the surrounding unit is heated in the continuous furnace.

15   Effects of the Present Method

          In conventional techniques in which the rim of the surrounding unit 40 is fastened by clips without the difference between the pressures outside and inside the surrounding unit 40, the center region of the surrounding unit is not given a  
20 pressure. As a result, the front panel 10 and the top of the barrier ribs on the back panel 20 are bonded while they are partially separated from each other. On the contrary, in the present embodiment, the sealing layer 41 hardens while the panels 10 and 20 are equally pressurized from outside. This  
25 enables the panels to be bonded together with almost no space

between the front panel 10 and the top of the barrier ribs.

Accordingly, the production method of the present embodiment facilitates the production of PDPs with excellent display quality which hardly generate a vibration when they are  
5 activated.

To gain the above effects, the vacuum pump 52 should be activated to cause the difference between the pressures outside and inside the surrounding unit 40 before the once-softened sealing layer 40 start to harden. However, there is no  
10 need of operating the vacuum pump 52 from start to finish of the sealing process. For example, it is possible to gain the effect of the pressure difference by activating the vacuum pump 52 after the sealing layer 41 has softened.

Furthermore, the panels 10 and 20 pressurize each  
15 other due to the difference between the inside pressure and outside pressure when the panels are bonded while the surrounding unit 40 is sealed with the difference in pressure. As a result, the pressure applied by the clips 42 required to prevent the displacement of the panels may be lower than the  
20 conventional methods.

It should be noted here that the clips 42 may not necessarily be used to prevent the displacement of the panels 10 and 20. However, the use of the clips ensures the prevention of the displacement. Furthermore, since the clips 42 also  
25 pressurize the sealing layer 41 inserted between the panels at

their rim. Due to this pressure, the sealing material spreads equally over the rim when it softens. This airtightly seals the rim.

Different materials may be used for the adhesive 26a and the sealing layer 41. However, when the same low-melting glass is used, as in the present embodiment, the sealing layer 41 and the adhesive 26a soften and harden with the same timing. That means, the surrounding unit 40 is sealed at the same time the pipe 26 and the air vent 21a of the back panel 20 are airtightly sealed.

#### Variations of the Present Embodiment

In the present embodiment, a low-melting glass is used as the adhesive 26a, and pressure is reduced inside the surrounding unit 40 while the adhesive 26a is softening. In such a case, the adhesive 26a may flow into the air vent 21a, so that the seal between the pipe 26 and the air vent 21a of the back panel 20 is broken.

To prevent the above problem, a crystallized glass that is crystallized at a temperature lower than the sealing layer 41 may be used. Such a crystallized glass is typically  $\text{PbO-ZnO-B}_2\text{O}_3$  frit glass.

The crystallized glass does not soften even if it is heated again to the initial crystallization temperature once it is heated to fluidize and then is crystallized and solidified. Accordingly, the above problem concerning the seal can be solved



by using the crystallized glass as the adhesive 26a and slowly heating the surrounding unit 40. With such an arrangement, the crystallized glass has been solidified before the sealing layer 41 starts to soften.

5           The same effects can be obtained by using, as the adhesive 26a, a glass that has a softening point slightly higher than the sealing layer 41.

          The above problem may be solved by previously connecting the pipe 26 to the air vent 21a of the back panel 20 using as the adhesive 26a a material that does not soften at the temperature of bonding the panels (e.g., a glass having a softening point considerably higher than the sealing layer 41, or a ceramic adhesive).

#### Embodiment 2

15           The present embodiment differs from Embodiment 1 in that after the surrounding unit 40 is formed by positioning the panels 10 and 20 to face each other, in the sealing process, an outer sealing layer 43 is further formed outside the sealing layer 41 formed between the panels 10 and 20 at the rim, as  
20 shown in FIGs. 5A and 5B.

          With the above arrangement, if the seal by the sealing layer 41 has a defect, the defect will be covered by the outer sealing layer 43, so that the sealing process is more ensured. In addition, the outer sealing layer 43 reduces the gap between  
25 the top of the barrier ribs and the front panel 10.

Formation of the outer sealing layer 43 provides other effects. For example, the outer sealing layer 43 before softening fixes the panels 10 and 20 and prevents them from being dislocated. Also, a certain degree of hermeticity of the inner space is kept even before the sealing layer 41 or the outer sealing layer 43 softens. As a result, a pressure can be applied to the panels 10 and 20 by driving the vacuum pump 52 to exhaust gas from the inner space.

To obtain the above effects, it is preferable that the same material is used for the sealing layer 41 and the outer sealing layer 43. For example, the paste including a sealing material (low-melting glass) used as the material of the sealing layer 41 can be applied to the outside of the sealing layer 41 of the surrounding unit 40 to form the outer sealing layer 43.

Also, the sealing layer 41 may be formed by applying a ceramic adhesive.

### Embodiment 3

The present embodiment differs from Embodiment 1 in that an anti-sealing-material-inflow rib 44 is formed inside the area where the sealing layer 41 is to be formed at the rim on either of or both the front panel 10 and the back panel 20, as shown in FIG. 6A.

By forming the anti-sealing-material-inflow rib 44 beforehand, it is possible to prevent the sealing layer 41 from flowing into the display area when the sealing layer 41 has

melted during the sealing process and the pressure inside the surrounding unit 40 has become lower than the pressure outside.

It is preferable that the anti-sealing-material-inflow rib 44 has about the same height as the barrier ribs 24. This is because: when the rib 44 is higher than the barrier ribs 24, a gap is generated between the front panel 10 and the top of the barrier ribs 24; and when the rib 44 is much lower than the barrier ribs 24, the effect of preventing the inflow of the sealing layer 41 cannot be expected.

An easy way to form the anti-sealing-material-inflow rib 44 is to form it using the same material as, and simultaneously with, the barrier ribs 24 on the back glass substrate 21 of the back panel 20, as shown in FIG. 6B.

#### 15 Embodiment 4

The present embodiment differs from Embodiment 1 in that during the sealing process, a pressure is applied from outside to the surrounding unit 40 to generate the difference between the pressures outside and inside the surrounding unit 40 while in Embodiment 1, the gas is exhausted from the inner space of the surrounding unit to reduce the inner pressure.

To achieve the above, the vacuum pump 52 is excluded from the sealing apparatus 50 of the present embodiment, but a pressurizing pump 53 is attached to the furnace 51 which can be, in the present embodiment, hermetically sealed, as shown in FIG.

7.

In the sealing process of the present embodiment, the surrounding unit 40 is heated and sealed in the furnace 51 while the inside of the furnace 51 is pressurized by the pressurizing pump 53, with the end of the pipe 26 is open to the air outside the furnace 51.

The method of sealing the surrounding unit 40 as described above provides the same effects as Embodiment 1 since the surrounding unit 40 is sealed while it receives a pressure from outside. More specifically, the sealing process is performed while the inner space of the surrounding unit 40 is kept to be substantially at atmospheric pressure and the outside of the surrounding unit 40 is at a high pressure.

#### Embodiment 5

In the present embodiment, the surrounding unit 40 is sealed using the same sealing apparatus 50 as Embodiment 4. However, the pipe 26 of the present embodiment is linear and does not go out the furnace 51, with its end sealed off, as shown in FIG. 8.

FIG. 9A shows the state of the surrounding unit 40 before the sealing layer 41 softens during the sealing process in which the surrounding unit 40 is sealed by the sealing layer 41, and FIG. 9B the state after the sealing layer 41 has softened. The sealing process of the present embodiment will be explained with reference to FIGs. 9A and 9B.

First, the sealing layer 41 is softened by heating the surrounding unit 40 in the furnace 51 while the inside of the furnace 51 is kept at atmospheric pressure, with the pressurizing pump 53 not activated.

5           As shown in FIG. 9A, gas can flow into or flow out from the surrounding unit 40 before the sealing layer 41 softens. Accordingly, the pressure in the inner space is almost the same as the atmospheric pressure when the sealing layer 41 softens.

10           After the sealing layer 41 and the adhesive 26a soften, the pressurizing pump 53 is activated to pressurize the inside of the furnace 51.

15           As shown in FIG. 9B, after the sealing layer 41 and the adhesive 26a have softened, the gas flow between the inside and outside of the surrounding unit 40 is blocked. When the inside of the furnace 51 is pressurized under these conditions, the inner space of the surrounding unit 40 remains almost the same as the atmospheric pressure, while the outside of the surrounding unit 40 is at a higher pressure than the inside.

20           When the inside of the furnace 51 is cooled at a high pressure as above, the sealing layer 41 hardens and the surrounding unit is sealed while it is pressurized from outside.

25           As understood from the above description, the method of the present embodiment provides the same effects as

## Embodiment 1.

The sealing process as above is followed by the vacuum exhaust process in which the end of the pipe 26 is cut and opened, the vacuum pump is connected to the end, and gas is exhausted from the inner space by the vacuum pump to produce a vacuum.

Embodiment 6

The present embodiment is basically the same as Embodiment 5 except that the pressure inside the surrounding unit 40 is reduced and the pressure outside the surrounding unit 40 is adjusted to be the atmospheric pressure while in Embodiment 5, the pressure outside the surrounding unit 40 is raised and the pressure inside the surrounding unit 40 is kept at atmospheric pressure to generate the difference between the pressures outside and inside the surrounding unit 40.

The sealing apparatus 50 of the present embodiment has the construction as shown in FIG. 8 except that the pressurizing pump 53 is replaced with a vacuum pump.

In the sealing process of the present embodiment, first the vacuum pump is activated to reduce the pressure in the furnace 51, and the surrounding unit 40 is heated to soften the sealing layer 41 while the inside of the furnace 51 is kept at a low pressure.

Before the sealing layer 41 softens, gas can flow into or flow out from the surrounding unit 40. As a result, the

inner space of the surrounding unit 40 is also at a reduced pressure when the sealing layer 41 softens.

After the sealing layer 41 and the adhesive 26a have softened, the vacuum pump is stopped so that the pressure inside the furnace 51 increases to the atmospheric pressure. At this stage, the gas flow between the inside and outside of the surrounding unit 40 has been blocked by the softened material. As a result, the pressure outside the surrounding unit 40 is higher than inside.

When the inside of the furnace 51 is cooled under the above conditions, the sealing layer 41 hardens and the surrounding unit is sealed while it is pressurized from outside.

As understood from the above description, the method of the present embodiment also provides the same effects as Embodiment 5.

#### Embodiment 7

In the present embodiment, a container whose inside is under a low pressure is connected to the surrounding unit, and the surrounding unit is sealed while gas is exhausted from the surrounding unit to the container to keep the pressure inside the surrounding unit low.

FIG. 10 is a perspective view showing how the surrounding unit 40 is sealed with the method of the present embodiment.

In Embodiment 1, the air vent 21a is opened beforehand at the rim on the back panel 20 outside the display area. In the present embodiment, an air vent 21b as well as the air vent 21a is opened at the rim.

5           As in Embodiment 1, the sealing layer 41 is formed at the rim of either of or both the front panel 10 and the back panel 20 on the surfaces facing each other. The front panel 10 and the back panel 20 are positioned properly to face each other and are put together to form the surrounding unit 40. The rim  
10 of the surrounding unit 40 is fastened by clips 42 so that the panels are not displaced.

A low-inner-pressure container 70 is attached to the air vent 21a of the surrounding unit 40. The pipe 26 of Embodiment 5 whose end is sealed off is attached to the air vent  
15 21b.

The low-inner-pressure container 70 is, as the pipe 26 is, made of a glass being resistant to the sealing temperature, and is composed of: a container body 71; and a connector 72 which projects from the container body 71 so as to  
20 be connected to the air vent 21a. The container body 71 is airtightly sealed by a gas-flow-cut layer 73 (FIG. 13A) formed inside the connector 72 which blocks the gas flow, and the inside of the container body 71 is kept at a reduced pressure.

An adhesive 74 is previously applied to the juncture  
25 of the connector 72 and the air vent 21a of the back panel 20.



The adhesive 26a is previously applied to the juncture of the pipe 26 and the air vent 21b of the back panel 20. These junctures are airtightly sealed by the adhesives. In the present embodiment, the material used for the sealing layer 41 is also used for the adhesives 26a and 74.

The material used for the sealing layer 41 or a low-melting glass whose softening point is slightly higher than the sealing layer 41 is used for the gas-flow-cut layer 73 so that the layer 73 softens almost at the same time or after the sealing layer 41 and the adhesives 26a and 74 soften.

Now, a method of producing the low-inner-pressure container 70 will be described with reference to FIGs. 11A and 11B.

The container body 71 and the connector 72 are manufactured using a technique used for processing glass products such as flask. Note that the container body 71 is provided with an exhaust pipe 72a used for exhausting gas to produce a vacuum, aside from the connector 72.

As shown in FIG. 11A, the connector 72 is filled with paste including a low-melting glass as the material of the gas-flow-cut layer 73. The gas-flow-cut layer 73 is formed by softening the paste using a heater such as a gas burner then hardening it again.

As shown in FIG. 11B, a vacuum pump is connected to the exhaust pipe 72a, and gas is exhausted from the container

body 71 to a certain degree of vacuum using the vacuum pump.

As shown in FIG. 11C, the exhaust pipe 72a is then  
chipped off using a gas burner while the certain degree of  
vacuum in the container body 71 is maintained, with the vacuum  
5 pump being connected to the exhaust pipe 72a.

The above process completes the low-inner-pressure  
container 70 whose container body 71 has the certain degree of  
vacuum.

FIG. 12 shows a belt-conveyor-type heating apparatus  
10 used for sealing the surrounding unit 40 in the present  
embodiment.

A heating apparatus 60 of the belt conveyor type  
includes: a furnace 61 for heating the panels; a conveyor belt  
62 for conveying the surrounding unit 40; and a plurality of  
15 heaters 63 disposed in the furnace 61 along the direction of  
conveyance.

The temperatures at a plurality of points between an  
entrance 64 and an exit 65 can be adjusted by the plurality of  
heaters 63. With this construction, the surrounding unit 40 can  
20 be heated or cooled with a desired temperature profile.

FIGs. 13A to 13C shows changes in the state of the  
surrounding unit 40.

The surrounding unit 40 with the low-inner-pressure  
container 70 and the pipe 26 is sealed as follows using the  
25 heating apparatus 60.

The surrounding unit 40 is placed on the conveyer belt 62 of the heating apparatus 60 and is conveyed in the furnace 61. The surrounding unit 40 is heated to a sealing temperature set to a degree slightly higher than the softening point of the gas-flow-cut layer 73 while conveyed in the furnace 61. The temperature increase speed in this heating is 10°C/minute, for example.

When the temperature of the surrounding unit 40 is lower than the softening point of the sealing layer 41, gas can flow into or flow out from the surrounding unit 40 via the sealing layer 41. On the other hand, as shown in FIG. 13A, the certain degree of vacuum in the container body 71 is maintained since gas flow from or to outside is blocked by the gas-flow-cut layer 73.

When the temperature of the surrounding unit 40 reaches the softening point of the sealing layer 41 by the heating, the sealing layer 41 softens. The softened sealing layer 41 airtightly seals the rims of the panels 10 and 20. At the same time, the adhesives 26a and 74 soften. As a result, the juncture of the low-inner-pressure container 70 and the back panel 20 and the juncture of the pipe 26 and the back panel 20 are also airtightly sealed.

The above process cuts the gas flow between the inner space of the surrounding unit 40 and outer space. More specifically, the gas flow is interrupted between the inside and

outside of a container complex composed of the surrounding unit 40 and the low-inner-pressure container 70.

The gas-flow-cut layer 73 softens almost at the same time or after the sealing layer 41 softens. When this happens, since the certain degree of vacuum in the container body 71 has been maintained, the gas-flow-cut layer 73 is broken by the difference between the pressures at its opposite sides, and the gas flows into the container body 71 from the inner space of the surrounding unit 40.

This reduces the pressure in the inner space of the surrounding unit 40, and allows the panels 10 and 20 to be pressurized from outside.

This pressurization reduces the gap between the front panel 10 and the top of the barrier ribs 24, as shown in FIG. 13C.

The surrounding unit 40 is left to stand (e.g., for 30 minutes) at the sealing temperature, then cooled and moves out of the furnace 61.

When the surrounding unit 40 is cooled to a degree equal to or below the softening point of the sealing layer 41, the sealing layer 41 hardens while the panels 10 and 20 are pressurized from outside, that is, while the gap between the front panel 10 and the top of the barrier ribs 24 is small.

After the sealing process by the heating apparatus 60 ends, the connector 72 is chipped off by a burner to block the

air vent 21b. The end of the pipe 26 is then cut, and the vacuum pipe is connected to the pipe 26. Gas is exhausted from the inner space of the surrounding unit 40 to produce a vacuum in the inner space.

5 Effects of Sealing Process of Present Embodiment

In the present embodiment, as in Embodiment 1, the panels 10 and 20 are bonded together while they are equally pressurized from outside. That means, the panels 10 and 20 are bonded while the front panel 10 and the top of the barrier ribs  
10 24 are in intimate contact in entirety.

In Embodiment 1, the vacuum pump is connected to the surrounding unit 40. In Embodiments 3 to 5, the pressure inside the furnace is reduced or increased. The present embodiment does not have such requirements. With such a construction, it  
15 is easy to perform the continuous sealing processes using a continuous heating apparatus such as the heating apparatus 60.

In the process of producing the low-inner-pressure container 70, it is preferable that the capacity and the degree of vacuum of the container body 71 are determined so that the  
20 pressure in the surrounding unit 40 is in a range of 10 to 600Torr after the gas-flow-cut layer 73 is broken. This is because; when the pressure in the surrounding unit 40 is below 10Torr, the sealing layer 41 may be broken by the difference between the pressures at its opposite sides; and when the  
25 pressure in the surrounding unit 40 is over 600Torr, the

pressure is as weak as to provide small effects.

#### Variations of the Present Embodiment

In the present embodiment, the gas-flow-cut layer 73 is made of a low-melting glass so that it melts by heat during the sealing process. However, the gas-flow-cut layer 73 may be made of such a material as melts or dissolves by application of an energy such as light or ultrasonic waves. In this case, the energy such as light or ultrasonic waves is applied to the gas-flow-cut layer 73 during the sealing process.

For example, the gas-flow-cut layer 73 is made of a novolak resin, and light is shone onto the novolak resin during the sealing process. Such a process can be operated in the same way as the present embodiment, and provides the same effects.

#### Embodiment 8

In the present embodiment, the sealing process is performed as follows. The surrounding unit 40 is heated to a high temperature and is sealed so that gas flow between the inner space and the outer space is interrupted, then the surrounding unit 40 is cooled and the pressure in the inner space is reduced to generate the difference between the pressures outside and inside the surrounding unit 40.

FIG. 14 shows a belt-conveyor-type heating apparatus used for sealing the surrounding unit 40 in the present embodiment. FIG. 15 shows the surrounding unit 40 placed in the belt-conveyor-type heating apparatus in the sealing process.

In the sealing process of the present embodiment, a linear pipe 26 whose end is opened is connected to the air vent 21a of the surrounding unit 40 (FIG. 15). The surrounding unit 40 is sealed using a belt-conveyor-type heating apparatus 80 shown in FIG. 14.

The heating apparatus 80 has the same construction as the heating apparatus 60 used in Embodiment 7 except that a burner 81 is disposed in the furnace 61. The burner 81 is used to heat and seal off the end of the pipe 26. The position of the burner 81 in the furnace 61 is set in an area where the surrounding unit 40 conveyed by the conveyer belt 62 in the furnace 61 reaches the highest temperature (peak temperature).

The surrounding unit 40 with the pipe 26 is sealed as follows by the heating apparatus 80.

The surrounding unit 40 is placed on the conveyer belt 62 of the heating apparatus 80 and is conveyed in the furnace 61. The surrounding unit 40 is heated to a sealing temperature (e.g., 500°C) set to a degree higher than the softening point of the sealing layer 41 (e.g., 380°C) while conveyed in the furnace 61. The temperature increase speed in this heating is 10°C/minute, for example.

The surrounding unit 40 is left to stand (e.g., for 10 minutes) at the peak temperature, then the end of the pipe 26 is heated and melted to be sealed off by the burner 81. At this stage, gas flow between the inner space and the outer space of

the surrounding unit 40 has been interrupted since the sealing layer 41 and adhesive 26a have softened, as in Embodiment 5 as shown in FIG. 9B. That is, the inner space is hermetically sealed.

5           The surrounding unit 40 is cooled after it passes the burner 81 while conveyed in the furnace 61, then moves out of the furnace 61. The pressure in a hermetically sealed space is proportionate to the absolute temperature (Boyle-Charles' law). As a result, the pressure in the inner space of the surrounding  
10 unit 40 decreases with decreasing temperature there. This generates a difference in pressure between the inside and outside of the inner space, allowing the panels 10 and 20 to be pressurized from outside. When the surrounding unit 40 having moved out of the furnace is further cooled to the softening  
15 point of the sealing layer 41, the sealing layer 41 and the adhesive 26a start to harden. That means, the panels 10 and 20 are bonded with a small gap between the front panel 10 and the top of the barrier ribs 24. Also, the pipe 26 is bonded to the back panel 20.

20           The sealing process as above is followed by the vacuum exhaust process in which the end of the pipe 26 is cut and opened, the vacuum pump is connected to the end, and gas is exhausted from the inner space by the vacuum pump to produce a vacuum.

25   Effects of Sealing Process of Present Embodiment



In the present embodiment, as in Embodiment 7, the panels 10 and 20 are bonded together while they are equally pressurized from outside. That means, the panels 10 and 20 are bonded while the front panel 10 and the top of the barrier ribs 24 are in intimate contact in entirety. With such a construction, it is easy to perform the continuous sealing steps using a continuous heating apparatus such as the heating apparatus 80.

It should be noted here that to produce sufficient effects, it is required that there is a sufficient difference between the pressures outside and inside the surrounding unit 40 when the sealing layer 41 hardens. Therefore, the end of the pipe should be cut at a temperature (peak temperature) 10°C higher than, preferably several tens °C higher than, the softening point of the sealing layer 41.

#### Variations of the Present Embodiment

In the present embodiment, the end of the pipe 26 is heated and sealed off by the burner 81 to cut the gas flow between the inside and outside of the surrounding unit 40. However, the following method can also be applied.

The end of the pipe 26 is previously filled with a low-melting glass whose softening point is slightly lower than the above peak temperature. With such an arrangement, the low-melting glass softens and seals off the end of the pipe before the surrounding unit 40 reaches the peak temperature, excluding

the necessity of burning the end of the pipe with the burner 81. When the temperature of the surrounding unit 40 starts decreasing from the peak temperature, the low-melting glass at the end of the pipe soon hardens. When the temperature of the  
5 surrounding unit 40 further decreases and reaches the softening point of the sealing layer 41, a difference between the pressures outside and inside the surrounding unit 40 is produced. As a result, the effects of the present embodiment are also produced by this variation.

10 Alternatively, as in Embodiment 7, an air vent 21b as well as the air vent 21a may be opened in the back panel 20, and the linear pipe 26 whose end is sealed off is connected to the air vent 21b. Here, the air vent 21a remains opened, where nothing is attached to the air vent 21a.

15 When the surrounding unit 40 reaches the peak temperature, a low-melting glass whose softening point is slightly lower than the peak temperature is dripped onto the air vent 21a to seal off the air vent 21a. In this case, as in the above variation, the low-melting glass hardens soon after the  
20 temperature of the surrounding unit 40 starts decreasing from the peak temperature. When the temperature of the surrounding unit 40 further decreases and reaches the softening point of the sealing layer 41, a difference between the pressures outside and inside the surrounding unit 40 is produced. As a result, the  
25 effects of the present embodiment are also produced by this

variation.

Embodiment 9

In the present embodiment, a container complex composed of a surrounding unit and a container is used. In the  
5 sealing process, the container complex is heated to a high temperature, the gas flow between the inside and outside of the container complex is interrupted at the high temperature, and the surrounding unit is cooled while the pressure inside the surrounding unit is low, resulting in the sealing of the  
10 surrounding unit.

FIGs. 16A to 16C show the sealing of the surrounding unit 40 in the present embodiment.

As shown in FIG. 16A, the surrounding unit 40 including the front panel 10 and the back panel 20 put together  
15 with the sealing layer 41 in between is placed in the furnace 51, as in Embodiment 1. The settings of the present embodiment differ from Embodiment 1 in that instead of the pipe 26, a container 90 whose end is opened is attached to the air vent 21a of the back panel 20.

20 The container 90 is composed of: a container body 91; a connector 92 protruding from the container body 91 and connecting the container body 91 and the air vent 21a; and an extension 93 extending from the container body 91 in the direction opposite to the connector 92, with its end opened.

25 In the initial settings for the sealing process, the

container 90 is attached to the air vent 21a with the container body 91 exposed outside the furnace 51. An adhesive 94 is applied beforehand between the connector 92 and the back panel 20 so that the juncture of the container 90 and the back panel 20 is airtightly sealed. In the present embodiment, the same material used for the sealing layer 41 is used as the adhesive 94.

An electric heater 95 for heating the container body 91 is attached to the container body 91.

After the above initial settings are complete, the surrounding unit 40 is heated in the furnace 51 to a temperature (e.g., 480°C) higher than the softening point of the sealing layer 41 (The temperature increase speed in this heating is 10°C/minute, for example). At the same time, the container body 91 is heated by the electric heater 95 to a chosen temperature (e.g., 200°C). The end of the extension 93 is then sealed off by the burner.

Here, as shown in FIG. 16B, the end of the extension 93 has been sealed off, and the sealing layer 41 and the adhesive 94 have softened. As a result, the gas flow between the inside and outside of the surrounding unit 40 and the gas flow between inside and outside (space in the furnace 51) of the container body 91 have been interrupted.

The electric heater 95 is then powered off to cool the container body 91 while the surrounding unit 40 is kept at a

temperature higher than the softening point of the sealing layer 41 in the furnace 51, as shown in FIG. 16C.

The decrease in the temperature of the container body 91 leads to the decrease in the pressure in the container body 91, which leads to the decrease in the pressure in the surrounding unit 40. Therefore, as in Embodiment 8, a difference between the pressures outside and inside the surrounding unit 40 is produced. This allows the panels 10 and 20 to be pressurized from outside.

The temperature inside the furnace 51 is then decreased. The sealing layer 41 and the adhesive 94 harden when the surrounding unit 40 is cooled to the softening point of the sealing layer 41. That means, the panels 10 and 20 are bonded with a small gap between the front panel 10 and the top of the barrier ribs 24. Also, the container 90 is bonded to the back panel 20.

The sealing process as above is followed by the vacuum exhaust process in which the end of the extension 93 is cut and opened, the vacuum pump is connected to the end, and gas is exhausted from the inner space by the vacuum pump to produce a vacuum.

#### Effects of Sealing Process of Present Embodiment

In the present embodiment, as in Embodiment 8, the panels 10 and 20 are bonded together while the front panel 10 and the top of the barrier ribs 24 are in intimate contact in

entirety.

In Embodiment 8, the surrounding unit 40 itself is cooled to decrease the pressure, while in the present embodiment, the pressure in the inner space of the surrounding  
5 unit 40 is reduced by decreasing the temperature of the container 90 which is arranged so that its temperature can be separately adjusted. As a result, unlike Embodiment 8, the surrounding unit 40 need not be heated to a temperature much higher than the softening point of the sealing layer 41. In the  
10 present embodiment, it will be sufficient for the surrounding unit 40 to be heated to a temperature equal to or higher than the softening point of the sealing layer 41.

#### Embodiment 10

In the present embodiment, a continuous heating  
15 apparatus is used to heat the container complex described in Embodiment 9. In the sealing process, the container complex is heated to a high temperature, the gas flow between the inside and outside of the container complex is interrupted at the high temperature, and the surrounding unit is cooled while the  
20 pressure inside the surrounding unit is low, resulting in the sealing of the surrounding unit.

FIG. 17 shows a belt-conveyor-type heating apparatus used for sealing the surrounding unit 40 in the present embodiment. FIG. 18 shows the surrounding unit 40 placed in the  
25 belt-conveyor-type heating apparatus in the sealing process.

In the sealing process of the present embodiment, as in Embodiment 8, the surrounding unit 40 to which the container 90 is attached via the air vent 21a by the adhesive 94 is heated while conveyed in the heating apparatus 100 so that the surrounding unit 40 is sealed, as shown in FIG. 17.

The heating apparatus 100 has the same construction as the heating apparatus 80 used in Embodiment 8 except that a burner 101 for sealing off the end of the extension 93 of the container 90 is disposed in the furnace 61. The position of the burner 101 in the furnace 61 is set in an area where the surrounding unit 40 conveyed by the conveyer belt 62 in the furnace 61 reaches a temperature equal to or higher than the sealing temperature (the softening point of the sealing layer 41).

In the heating apparatus 100, a ceiling plate 61a is lowered in height between the burner and the exit. The ceiling plate 61a has a slot 61b so that the connector 92 of the container 90 can pass through it as the surrounding unit 40 is conveyed on the belt. The ceiling plate 61a also has a window 61c so that the container body 91 can pass through it as the surrounding unit 40 is conveyed on the belt.

The surrounding unit 40 with the container 90 is placed on the conveyer belt 62 of the heating apparatus 100 and is conveyed in the furnace 61. The surrounding unit 40 is heated to a sealing temperature, and is left to stand for a

while at the sealing temperature. At the same time, the end of the extension 93 is heated to be sealed off by the burner 101.

At this stage, the surrounding unit 40 is in the same state as that shown in FIG. 16B of Embodiment 9. That is, the  
5 end of the extension 93 has been sealed off, and the sealing layer 41 and the adhesive 94 have softened. As a result, the gas flow between the inside and outside of the surrounding unit 40 and the gas flow between inside and outside of the container body 91 have been interrupted.

10 After passing the burner 101, the surrounding unit 40 is maintained at a temperature equal to or higher than the softening point of the sealing layer 41 since it moves inside the furnace 61, while the container body 91 is cooled after passing the window 61c since it is out of the furnace 61 (above  
15 the ceiling 61a).

The decrease in the temperature of the container body 91 leads to the decrease in the pressure in the container body 91, which leads to the decrease in the pressure in the surrounding unit 40, as in the state in Embodiment 9 shown in  
20 FIG. 16C. This produces a difference between the pressures outside and inside the surrounding unit 40, allowing the panels 10 and 20 to be pressurized from outside.

The sealing layer 41 and the adhesive 94 harden when the surrounding unit 40 is cooled to the softening point of the  
25 sealing layer 41. That means, the panels 10 and 20 are bonded



with a small gap between the front panel 10 and the top of the barrier ribs 24. Also, the container 90 is bonded to the back panel 20. The surrounding unit 40 then moves out of the furnace 61.

5           The sealing process as above is followed by the vacuum exhaust process in which the end of the extension 93 is cut and opened, the vacuum pump is connected to the end, and gas is exhausted from the inner space by the vacuum pump to produce a vacuum.

10           It is preferable in maintaining the temperature in the furnace 61 that the window 61c is provided with a shutter and that the shutter is opened only when the container body 91 passes through the window 61c.

#### Variations of Methods for Reducing Pressure in Inner Space

15           In Embodiments 9 and 10, the end of the extension 93 is initially opened, then it is sealed off by a burner after the container body 91 is heated so that the gas flow between the inside and outside of the surrounding unit 40 and the gas flow between inside and outside of the container body 91 are  
20 interrupted. However, if the end of the extension 93 is initially sealed off, this can also be achieved by heating the container body 91 before the sealing layer 41 softens, and cooling the container body 91 after the sealing layer 41 softens. With this method, the pressure in the inner space is  
25 also reduced.

In Embodiments 8 to 10, the surrounding unit 40 is cooled or the container 90 connected to the surrounding unit 40 is cooled to reduce the pressure in the inner space of the surrounding unit 40. However, this may be achieved by reducing  
5 the number of gas molecules in the inner space.

For example, an oxygen gas is previously encapsulated into the surrounding unit 40 or the container 90 connected to the surrounding unit 40. A laser beam is shone onto the oxygen gas when the sealing layer 41 has softened. The oxygen gas then  
10 turns to ozone, reducing the number of gas molecules contained in the inner space. This also reduces the pressure in the inner space of the surrounding unit 40.

Alternatively, a gas adsorbing material (e.g., getter) and a gas are initially enclosed in the surrounding unit 40 or  
15 the container 90 connected to the surrounding unit 40, where the gas adsorbing material is activated when it is given a stimulus such as heat or light, and the gas is held by adsorption on the surface of the gas adsorbing material when the material is activated. It is possible with this construction to reduce the  
20 number of gas molecules contained in the inner space of the surrounding unit 40 and the pressure therein by making an arrangement so that the gas adsorbing material is activated when the sealing layer 41 has softened.

To achieve the above, such a gas adsorbing material  
25 as is activated at a temperature higher than the softening point

of the sealing layer 41 may be used. Alternatively, a laser beam may be shone onto the gas adsorbing material so as to activate it when the sealing layer 41 has softened.

#### Embodiment 11

5           The present embodiment is basically the same as Embodiment 1 except that a joint layer 45 is formed on top of the barrier ribs 24 on the back panel 20 before the surrounding unit 40 is formed. The joint layer 45 joints the barrier ribs 24 and the front panel 10.

10           The material for the joint layer 45 should not badly affect the operation of the PDP and needs to have an ability to joint the barrier ribs 24 and the front panel 10. In the present embodiment, a low-melting glass used for the sealing layer 41 is used.

15           The joint layer 45 is formed by applying a paste containing the joint material (low-melting glass) to the top of the barrier ribs 24 with the screen printing method, then baking the applied paste.

20           First, the joint layer 45 is formed as described above. A difference between the pressures outside and inside the surrounding unit 40 is then generated so that the pressure inside is lower than the pressure outside, as in Embodiment 1. This renders the panels 10 and 20 equally pressurized from outside. At this stage, the front panel 10 and the top of the  
25 barrier ribs 24 are in intimate contact in entirety. When the

sealing layer 42 and the joint layer 45 harden under this condition, the front panel 10 and the top of the barrier ribs 24 are tightly jointed.

5 The PDPs manufactured with the method of the present embodiment, in which the front panel 10 and the top of the barrier ribs 24 are jointed in entirety, are more excellent than those of Embodiment 1 in terms of the effects of restricting the vibration at PDP activation and of improving PDP display quality.

10 In the present embodiment, a technique of previously forming the joint layer 45 on top of the barrier ribs 24 is described based on Embodiment 1. However, the technique can also be applied to Embodiments 2 to 10. When the joint layer 45 is formed on top of the barrier ribs 24 in Embodiments 2 to 10,  
15 the PDPs manufactured with these methods are more excellent than those of Embodiments 2 to 10 in terms of the effects of restricting the vibration at PDP activation and of improving PDP display quality since the front panel 10 and the top of the barrier ribs 24 are jointed in entirety and it is possible for  
20 the inner space to be filled with the discharge gas at a high pressure.

#### Embodiment 12

The present embodiment is basically the same as Embodiment 1 except that before the sealing process, an anti-  
25 deformation rib 46 is formed near the area where the sealing

layer 41 is to be formed at the rim on either of or both the front panel 10 and the back panel 20, as shown in FIGS. 20A and 20B.

In an example shown in FIG. 20A, the anti-deformation  
5 rib 46 is formed along outside the sealing layer 41. In an example shown in FIG. 20B, the anti-deformation ribs 46a and 46b are formed along outside and inside the sealing layer 41, respectively.

With such arrangements, the panels 10 and 20 are  
10 prevented from becoming deformed even if they are pressurized at their rims by the clips 42.

When such anti-deformation ribs are not formed near the sealing layer 41, the pressure given by the clips 42 acts on the panels 10 and 20 as follows when the sealing layer 41  
15 softens during the sealing process. As shown in FIG. 20D, at the rim of the surrounding unit 40, the panels 10 and 20 tend to deform by approaching each other (in the direction indicated by arrow A in the drawing). When this happens, the panels 10 and 20 tend to deform at the center by distancing from each other  
20 (in the direction indicated by arrow B in the drawing) by the action of a lever. Such actions are not preferable since they widen the gap between the front panel and the top of the barrier ribs 24.

On the other hand, when the anti-deformation ribs 46  
25 are formed as described above, deformation of the panels 10 and

20 by the pressure of the clips 42 does not occur even if the sealing layer 41 softens during the sealing process.

Accordingly, it is possible to enhance the effect of reducing the gap between the front panel 10 and the top of the barrier ribs 24.

Alternatively, the deformation of the panels 10 and 20 by the pressure of the clips 42 can be prevented by arranging the clips 42 so that the pressurizing point of each clip is placed inside the edge of the panels, more specifically, so that the clips 42 pressurize the image display area, as shown in FIG. 20C.

Note that the example shown in FIG. 20B, in which the anti-deformation rib is formed along inside the sealing layer 41 as well as outside, also has an effect of preventing the softened sealing layer 41 from flowing into the display area when the pressure outside becomes higher than the pressure inside. That is to say, the anti-deformation rib 46b also serves as the anti-sealing-material-inflow rib 44 described in Embodiment 3.

It is preferable that the anti-deformation rib 46 is formed to have the same height as the barrier ribs 24 when the panels 10 and 20 are put together to face each other.

This is because: when the rib 46 is higher than the barrier ribs 24, a gap is generated between the front panel 10 and the top of the barrier ribs 24; and when the rib 46 is much

lower than the barrier ribs 24, the effect of preventing the deformation of the panels 10 and 20 cannot be expected.

An easy way to form the anti-deformation rib 46 is to form it using the same material as, and simultaneously with, the barrier ribs 24 on the back glass substrate 21 of the back panel 20, as the anti-sealing-material-inflow rib 44 is formed.

FIGs. 21A to 21F are partial front views showing the shapes the anti-deformation rib 46 formed on the pack panel 20. In the drawings, the diagonally shaded areas C represent the areas in which the sealing layer 41 is to be formed.

In FIG. 21A, anti-deformation ribs 46a and 46b are formed as linear lines along outside and inside the diagonally shaded area C.

In FIG. 21B, a plurality of anti-deformation ribs are formed at regular intervals in the diagonally shaded area C, crossing over them.

In FIG. 21C, a plurality of anti-deformation ribs are formed at random in the diagonally shaded area C.

In FIG. 21D, a plurality of short anti-deformation ribs 46a are formed diagonally at regular intervals in the diagonally shaded area C, and anti-deformation ribs 46b are formed as linear lines along inside the area C.

In FIG. 21E, anti-deformation ribs 46a are formed as short dashed lines along outside the diagonally shaded area C, and anti-deformation ribs 46b are formed as linear lines along

inside the area C in parallel.

In FIG. 21F, a plurality of anti-deformation ribs 46a are formed at regular intervals in the diagonally shaded area C, crossing over them, and anti-deformation ribs 46b are formed as  
5 linear lines along inside the area C in parallel.

#### Variations of the Present Embodiment

The techniques disclosed in the above embodiments such as the techniques of forming the anti-deformation ribs 46 or the techniques of pressurizing the image display area by the clips  
10 42 can be applied to general sealing processes for manufacturing PDPs, not limited to the sealing process in which a difference between the pressures outside and inside the surrounding unit 40 is generated so that the pressure inside is lower than the pressure outside.

#### Embodiment 13

In the present embodiment, an energy is intensively radiated onto the top of the barrier ribs to bond the top of the barrier ribs to the front panel after the sealing process is performed in a manner described in one of Embodiments 1 to 10.

20 FIGS. 22A to 22C show the process of bonding the top of the barrier ribs to the front panel by radiating a laser beam.

First, the front panel 10 and the back panel 20 are put together to form the surrounding unit 40, and the panels are  
25 bonded together by softening and then hardening the sealing



layer 41, using a method among those described in Embodiments 1 to 10 (FIG. 22A).

Secondly, as shown in FIG. 22B, a laser beam is radiated from a laser processing apparatus 200 onto the top of the barrier ribs via the front panel 10 of the surrounding unit 40 having been formed.

As will be described later in detail, the laser processing apparatus 200 includes a plurality of components which operate to radiate a laser beam as follows. A YAG laser oscillator 201 emits pulses of a laser beam to a laser head 203, while the laser head 203 scans a work (surrounding unit 40) vertically and horizontally (in the directions X and Y shown in FIG. 22B). A converging lens 204 disposed in the laser head 203 converges the laser beam on the surface of the work as an elliptical spot.

When a laser beam is radiated onto the top of the barrier ribs, the top is intensely heated to a high temperature higher than the softening point (e.g., 500-600°C) of the barrier rib material. When this happens, the material softens (melts) and hardens later. This allows the front panel and the top of the barrier ribs to bond together since they have been in intimate contact by this time.

Accordingly, the front panel and the top of the barrier ribs are bonded together in entirety by moving the spot of the radiated laser beam on the top of the barrier ribs along

the direction of the length of the surrounding unit 40 by scanning the top in the direction as indicated by the arrow sign in FIG. 22B (the diagonally shaded area in the drawings indicate the bonded area).

5           FIG. 22C shows a sequence of dot-like bonded areas (the diagonally shaded areas in the drawing) which are formed by radiating the laser beam intermittently. However, the bonded areas may be formed as straight lines by radiating the laser beam with very short dashes or by radiating continuously.

10           The front panel and the top of the barrier ribs can be bonded together by radiating a laser beam as described above even if there is no difference between the pressures outside and inside the surrounding unit 40. However, it is preferable to perform this process maintaining the state in which the pressure  
15 of the inner space of the surrounding unit 40 is lower than the pressure outside as described in the sealing process of Embodiments 1-5 and 7-10. This is because the front panel and the top of the barrier ribs are bonded together while they are in intimate contact.

20           FIG. 23 is a perspective view showing a specific laser processing apparatus 200.

          The laser processing apparatus 200 shown in FIG. 23 is classified as gantry-type. In this laser processing apparatus 200, a table 202 is supported to be able to move in  
25 the X direction as shown in FIG.23. An arch 210 is formed to

overstride the table 202. A laser torch 211 is supported on the arch 210 to be able to move in the Y direction. The laser torch 211 and the table 201 are precisely driven by a stepping motor (not illustrated).

5           The surrounding unit 40 is fixed on the table 202 by a vacuum chuck mechanism.

          The laser head 203 is fixed on the laser torch 211. The laser beam emitted from the laser oscillator 201 is guided to the laser head 203 via an optical fiber cable 212 made of  
10   quartz glass. Preferably, the laser oscillator 201 is achieved by: a YAG laser oscillator 201 which can emit a strong beam in a short time; or a CO<sub>2</sub> laser oscillator. The output of the laser oscillator 201 is 10mW, for example.

          First, the surrounding unit 40 is loaded on the table  
15   202 so that each barrier rib extends along the X direction shown in FIG. 23. The first barrier rib is then bonded to the front panel by moving the spot of the radiated laser beam on the top of the barrier rib in the X direction. The spot is moved by the pitch of the barrier ribs in the Y direction. This process is  
20   repeated for the rest of the barrier ribs until the entire top of the barrier ribs is bonded.

#### Effects of Present Embodiment

          In the present embodiment, the front panel and the top of the barrier ribs are bonded together in entirety. As a  
25   result, the effects of restricting the vibration at PDP

activation and of improving PDP display quality are as excellent as Embodiment 11.

The results of experiments performed by driving the PDPs manufactured with the method of the present embodiment show  
5 that the resonance of the barrier ribs and the front panel does not occur, while it occurs to conventional products. Also, the results show that the noise level of the PDPs of the present embodiment is one-tenth of conventional products, and that no cross talk between cells is objected.

10 The present embodiment has another advantage that, unlike Embodiment 11 or the like, the front panel and the top of the barrier ribs are bonded together without the application of an adhesive to the top of the barrier ribs, resulting in the simplification of the manufacturing process.

15 According to the method of the present embodiment, the front panel and the top of the barrier ribs are bonded together by the material of the barrier ribs, not by an adhesive. This produces an advantage. In case the image display area of PDP includes an adhesive, the adhesive may release an impurity into  
20 the discharge gas. However, there is no such possibility in the PDPs manufactured with the method of the present embodiment.

However, it is also possible that the joint layer 45 is previously formed on top of the barrier ribs 24 as in Embodiment 11, then after the surrounding unit 40 is formed, the  
25 laser beam is radiated onto the joint layer 45 to bond the front

panel and the top of the barrier ribs as in the present embodiment. This method ensures the bonding though the above advantages are not obtained.

Note that when a material such as the black filler  
5 which improves the absorption of laser beam is mixed with the material of the joint layer 45, the bonding is performed more securely.

#### Variations of Present Embodiment

Typically, such a laser processing apparatus 200 as  
10 described in the present embodiment can perform a precise, two-dimensional laser processing onto the work by micro-orders of magnitude. The bonding may be performed more precisely by disposing an apparatus for observing the surface of the work as described below.

15 FIG. 24 shows the laser processing apparatus 200 being provided with an observation head 205, as well as the laser head 203. The observation head 205 includes: a probe beam emitter 206 for radiating a probe beam onto the surface of the work; and a detector 207 for detecting the probe beam reflected from the  
20 surface of the work. The observation head 205 scans a work (surrounding unit 40) vertically and horizontally (in the directions X and Y shown in FIG. 22B) as the laser head 203 does.

A controller 208 monitors the shape of the barrier  
25 ribs 24 by allowing the observation head 205 to scan and

receiving signals from the detector 206 (i.e., the controller 208 stores x-y coordinate values on the table 202 as the information indicating positions of the barrier ribs).

The controller 208 also fine-tunes the laser head 203  
5 in the Y direction using the stored positional information on the barrier ribs so that the laser beam is radiated onto the exact center of each barrier rib when the laser head 203 scans the barrier ribs in the X direction.

Such an arrangement ensures that the laser beam is  
10 radiated onto the center of each barrier rib even if the barrier ribs 24 are curved (snaky) or are partially lacking, resulting in a high-precision bonding of the front panel and the barrier ribs.

Alternatively, the intensity of the laser beam may be  
15 adjusted by monitoring the width of the barrier ribs or the reflectivity of the laser beam using the laser processing apparatus 200 shown in FIG. 24.

When the top of the barrier ribs is softened by radiating a laser beam there, it is considered that the wider  
20 the barrier rib is or the higher the reflectivity is, the less the temperature rises by the laser radiation and the smaller the bonded area is. On the contrary, when the joint layer is formed on top of the barrier ribs, the bonded area may increase when the barrier rib is wider since the amount of joint material also  
25 increases. Accordingly, when the radiation intensity of the

laser beam is fixed, the bonding state (the area of the barrier ribs that melts) tends to vary for each position on the top of the barrier ribs as the width of the rib or the reflectivity varies.

5           The above problem can be solved by controlling the radiation intensity or the radiation angle of the laser beam in accordance with the monitored width and the monitored reflectivity at each position on the top of the barrier ribs.

          In the present embodiment, the bonding process in  
10   which the front panel 10 and the top of the barrier ribs 24 are bonded by radiation of the laser beam is performed after the sealing process in which the pressure inside the surrounding unit 40 kept lower than the pressure outside. However, the bonding process may be performed after a conventional sealing  
15   process. Although, in this case, the bonding is thought to be inferior than the present embodiment since they are bonded while there is more gap between the front panel 10 and the top of the barrier ribs.

          In the present embodiment, the bonding process in  
20   which the front panel 10 and the top of the barrier ribs 24 are bonded by radiation of the laser beam is performed after the sealing process. However, the bonding process may be performed prior to or in parallel to the sealing process.

          When the bonding process is performed in prior to the  
25   sealing process, it is preferable that to the panels in

entirety, the rim of the surrounding unit 40 is sealed by an outer sealing layer as in Embodiment 2, then the panels are bonded while gas is exhausted from the inner space of the surrounding unit 40 to reduce the pressure inside.

5 In the present embodiment, the top of the barrier ribs or the adhesive is softened (melted) by radiating a laser beam thereon. However, the top of the barrier ribs or the adhesive may also be softened by radiating an energy such as ultrasonic waves onto the top of the barrier ribs or intensively heating  
10 the front panel 10 by a heater.

Alternatively, the surrounding unit 40 may be formed by putting the front and back panels together while the front panel has been heated and is around the softening point of the barrier ribs 24 so that the top of the barrier ribs or the  
15 adhesive in contact with the front panel 10 is softened to bond the front panel and the barrier ribs.

#### Embodiment 14

In the present embodiment, an exhaust pipe sealing apparatus which can chip off an exhaust pipe (e.g., the pipe 26  
20 described in Embodiment 1) without difficulty will be described.

FIG. 25 is a perspective view showing an exhaust pipe sealing apparatus 310 attached to an exhaust pipe 300. FIG. 26 is a sectional view of the exhaust pipe sealing apparatus 310  
25 attached to the exhaust pipe 300.



Although the surrounding unit is not illustrated in FIGs. 25 and 26, the base of the exhaust pipe 300, which is the lower part of it in the drawings, is connected to the air vent of the back panel (see FIG. 5).

5           The exhaust pipe sealing apparatus 310 is composed of: a heating unit 311 for heating the exhaust pipe 300; and a restriction member 315 for restricting the position of the heating unit 311 in relation to its attachment to the exhaust pipe 300.

10           The heating unit 311 is composed of: a cylindrical support member 312 having a diameter larger than the outer diameter of the exhaust pipe 300; and an electric heater 313 which is a coil wound inside the support member 312 in entirety.

15           The restriction member 315 is a cylindrical member at the center of which a hole for inserting the exhaust pipe 300 is formed around the center axis. An end of the restriction member 315 (the lower end in the drawing) is formed as a fit-in member 316 having a smaller diameter than the restriction member 315 so  
20           that the fit-in member 316 is fitted into an end of the heating unit 311 (the upper end in the drawing).

          The restriction member 315 is formed so as to be divided into two parts (which are referred to as restriction member parts 315a and 315b) by a plane passing the center  
25           axis.

A desirable material for the restriction member 315 is a ceramic which has a high insulation and a softening point higher than the exhaust pipe 300.

It is desirable that the hole of the restriction member 315 has a diameter only slightly larger than the outer diameter of the exhaust pipe 300. This is because if the diameter of the member 315 is much larger than the outer diameter of the pipe 300, the member 315 rattles as hard as cannot perform the positional restriction.

Also, it is desirable that the outer diameter of the fit-in member 316 is properly smaller than the inner diameter of the heating unit 311. This is because: when the former is much larger than the latter, the heating unit 311 contacts the electric heater 313; and when the former is much smaller than the latter, the electric heater 313 rattles as hard as cannot perform the positional restriction.

The above-constructed exhaust pipe sealing apparatus 310 seals the exhaust pipe 300 as follows.

First, the heating unit 311 is placed at a position where the exhaust pipe 300 is to be chipped off. Then, the fit-in member 316 of the restriction member 315 is fitted in the heating unit 311. Lastly, the electric current is passed through the electric heater 313 to heat and chip off the exhaust pipe 300.

Effects of Present Embodiment

When only the electric heater 313 is used to chip off the exhaust pipe 300 without using the restriction member 315, it often happens that the electric heater 313 melts the exhaust pipe 300 and the melted exhaust pipe 300 sticks to the heater 313, resulting in breakage of the pipe 300. On the contrary, when the exhaust pipe 300 is chipped off as described above using the restriction member 315, the chip-off is carried out without allowing the electric heater 313 to contact the exhaust pipe 300.

The restriction member 315 is formed so as to be divided into two parts by a plane passing the center axis. This facilitates the attachment of the member 315 to the place between the exhaust pipe 300 and the electric heater 313 after the heating unit 311 is fitted to the exhaust pipe 300.

#### Variations of Present Embodiment

In the present embodiment, the restriction member 315 is formed so as to be divided into the restriction member parts 315a and 315b. However, the restriction member 315 may not necessarily be formed so as to be divided into parts.

The exhaust pipe sealing apparatus 310 shown in FIG. 26 is constructed so that an end of the heating unit 311 can be fitted to outside of the fit-in member 316 of the restriction member 315. However, the exhaust pipe sealing apparatus 310 may be constructed so that an end of the heating unit 311 is fitted to inside of the fit-in member 316 of the restriction member

315, as shown in FIG. 27. This variation also produces the same effects as the present embodiment.

The exhaust pipe sealing apparatus 310 shown in FIG. 26 is constructed so that an end of the heating unit 311 is fitted to the restriction member 315. However, the exhaust pipe sealing apparatus 310 may be constructed so that both ends of the heating unit 311 are fitted to the restriction member 315, as shown in FIG. 28. That is, the restriction member 315 restricts the position of the heating unit 311 at two points. This enables the restriction member 315 to restrict the positions of the electric heater 313 and the exhaust pipe 300 more surely and prevent them from contacting each other.

The exhaust pipe sealing apparatus 310 shown in FIG. 26 is constructed so that the restriction member 315 and the heating unit 311 are formed as separate units. However, the restriction member 315 and the heating unit 311 may be formed as one unit as shown in FIG. 29 of an exhaust pipe sealing apparatus 320.

The exhaust pipe sealing apparatus 320 shown in FIG. 29 is formed as one unit so that an electric heater 322 is wound inside a cylindrical restriction unit 321 on an end of which a lid 321a is formed. At the center of the lid 321a, a hole for inserting the exhaust pipe 300 is formed.

FIG. 30 shows an exhaust pipe sealing apparatus 330 which is also formed as one unit so that an electric heater 332

is wound inside a cylindrical restriction unit 331 on both ends of which lids 331a and 331b are formed.

The exhaust pipe sealing apparatus 330 can be divided into two parts by a plane passing the center axis. FIG. 30 only  
5 shows one of the divided parts.

The exhaust pipe 300 can be chipped off by the exhaust pipe sealing apparatus 320 or 330, as the exhaust pipe sealing apparatus 310, by fitting the apparatus 320 or 330 to the exhaust pipe 300 then passing the electric current through the  
10 electric heater.

#### Variations of Embodiments 1 to 14

In the PDPs of the above embodiments, the barrier ribs 24 are formed on the back panel 20. However, the barrier ribs may be formed on the front panel.

15 In the above embodiments, the present invention is applied to AC-type PDPs. However, the present invention can generally be applied to the production of gas discharge panels as far as they are produced by bonding a panel to another panel on which barrier ribs are formed.

#### 20 INDUSTRIAL APPLICABILITY

The gas discharge panels, especially PDPs, manufactured with the method or apparatus of the present invention can be used as displays of computers or TVs and are especially suitable for large-screen displays.

CLAIMS

1. A gas discharge panel production method comprising:

a surrounding unit forming step for forming a surrounding unit by putting a first panel and a second panel together, wherein barrier ribs for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are put together to face each other with the barrier ribs in between; and

a sealing step for sealing the surrounding unit with a sealing material inserted between the first panel and the second panel at the rim, wherein

the sealing step includes:

a pressure adjustment sub-step for adjusting pressure so that pressure inside the surrounding unit is lower than pressure outside the surrounding unit.

2. The gas discharge panel production method of Claim 1, wherein

the pressure adjustment sub-step starts before the sealing material hardens.

3. The gas discharge panel production method of Claim 2, wherein

the sealing material softens when an energy is given

from outside, and

in the sealing step, the sealing material is first softened then hardened to seal the surrounding unit.

4. The gas discharge panel production method of Claim 2 or Claim 3, wherein

in the surrounding unit forming step, a connection path which connects inside of the surrounding unit to outside of the surrounding unit is formed in the surrounding unit, and

in the pressure adjustment sub-step, gas is exhausted from inside of the surrounding unit to outside of the surrounding unit via the connection path.

5. The gas discharge panel production method of Claim 4, wherein

the surrounding unit is provided with an air vent which connects inside of the surrounding unit to outside of the surrounding unit, and a pipe is connected to the air vent with a crystallized glass in between, and

in the pressure adjustment sub-step, gas is exhausted from inside of the surrounding unit to outside of the surrounding unit via the pipe.

6. The gas discharge panel production method of Claim 1, wherein

the sealing step includes:

an airtightly seal sub-step for interrupting gas flow between inside and outside of the surrounding unit, and

in the pressure adjustment sub-step, pressure inside the surrounding unit after the airtightly seal sub-step is adjusted to be lower than before the airtightly seal sub-step.

7. The gas discharge panel production method of Claim 6, wherein

in the pressure adjustment sub-step, a container whose inside is under a pressure lower than the pressure inside the surrounding unit is used to reduce the pressure inside the surrounding unit.

8. The gas discharge panel production method of Claim 7, wherein

in the surrounding unit forming step, the container is attached to the surrounding unit, wherein a shielding material interrupts gas flow between the container and the surrounding unit, and

in the pressure adjustment sub-step, the interruption by the shielding material is released to reduce the pressure inside the surrounding unit.

9. The gas discharge panel production method of Claim 8,



wherein

the shielding material either melts or dissolves when a stimulus is given, and

in the pressure adjustment sub-step, the stimulus is given to the shielding material so that the shielding material melts or dissolves to release the interruption by the shielding material and enable the gas to flow between the container and the surrounding unit.

10. The gas discharge panel production method of Claim 6, wherein

in the surrounding unit forming step, a container is attached to the surrounding unit, wherein inside of the container is connected to inside of the surrounding unit, and

in the pressure adjustment sub-step, to reduce the pressure inside the surrounding unit, temperature in the container is reduced to a degree lower than a degree before the airtightly seal sub-step.

11. The gas discharge panel production method of Claim 6, wherein

in the pressure adjustment sub-step, to reduce the pressure inside the surrounding unit, temperature in the surrounding unit is reduced to a degree lower than a degree before the airtightly seal sub-step.

12. The gas discharge panel production method of Claim 6, wherein

in the airtightly seal sub-step, the surrounding unit is heated to soften the sealing material and seal the rim of the surrounding unit so that gas flow between inside and outside of the surrounding unit is interrupted.

13. The gas discharge panel production method of Claim 12, wherein

in the surrounding unit forming step, a connection path which connects inside of the surrounding unit to outside of the surrounding unit is formed in the surrounding unit, and

in the airtightly seal sub-step, the surrounding unit is heated to soften the sealing material and seal the rim of the surrounding unit and the connection path is sealed so that gas flow between inside and outside of the surrounding unit is interrupted.

14. The gas discharge panel production method of Claim 6, wherein

a gas adsorption member is disposed in the surrounding unit in the surrounding unit forming step, or the gas adsorption member is disposed in a container whose inside is connected to inside of the surrounding unit, and

in the pressure adjustment sub-step, the pressure inside the surrounding unit is reduced by a gas adsorption action of the gas adsorption member.

15. The gas discharge panel production method of Claim 14, wherein

the gas adsorption member holds gas by adsorption in reaction to a stimulus given from outside, and

in the pressure adjustment sub-step, the stimulus is given to the gas adsorption member so that the gas adsorption member holds gas by adsorption.

16. The gas discharge panel production method of Claim 15, wherein

in the pressure adjustment sub-step, the stimulus is given to the gas adsorption member so that the gas adsorption member holds gas by adsorption after the airtightly seal sub-step starts.

17. The gas discharge panel production method of Claim 6, wherein

in the surrounding unit forming step, a container is attached to the surrounding unit, wherein inside of the container is connected to inside of the surrounding unit, and the surrounding unit is filled with a gas whose molecules bond

to each other, wherein the container may also be filled with the gas whose molecules bond to each other, and

in the pressure adjustment sub-step, the pressure inside the surrounding unit is reduced as the molecules of the gas bond to each other.

18. The gas discharge panel production method of Claim 17, wherein

the molecules of the gas bond to each other when a stimulus is given from outside, and

in the pressure adjustment sub-step, the stimulus is given to the gas so that the molecules of the gas bond to each other.

19. The gas discharge panel production method of Claim 18, wherein

in the pressure adjustment sub-step, the stimulus is given to the gas after the airtightly seal sub-step starts.

20. The gas discharge panel production method of Claim 1, wherein

the sealing step includes:

an airtightly seal sub-step for interrupting gas flow between inside and outside of the surrounding unit, and

in the pressure adjustment sub-step, pressure outside

the surrounding unit after the airtightly seal sub-step is adjusted to be higher than before the airtightly seal sub-step.

21. The gas discharge panel production method of one of Claims 6 to 20, wherein

the sealing material softens when a stimulus is given from outside, and

in the airtightly seal sub-step, the stimulus is given to the sealing material to soften the sealing material so that gas flow between inside and outside of the surrounding unit is interrupted, and

the pressure adjustment sub-step is performed after the airtightly seal sub-step starts.

22. The gas discharge panel production method of one of Claims 6 to 20, wherein

the sealing step includes:

a preparatory sealing sub-step for sealing the surrounding unit with another sealing material different from the sealing material before the surrounding unit is sealed with the sealing material in the sealing step, the other sealing material being inserted between the first panel and the second panel at the rim.

23. The gas discharge panel production method of one of Claims 1 to 3 and 6 to 20, wherein

in the sealing step, the surrounding unit is sealed while the first panel and the second panel is pressurized by fastening tools pinching the first panel and the second panel at the rim.

24. The gas discharge panel production method of Claim 23, wherein

in the sealing step, the first panel and the second panel are pinched by the fastening tools at an area in which the barrier ribs are formed.

25. The gas discharge panel production method of Claim 23, wherein

an anti-deformation member is disposed at the rim of at least one of the first panel and the second panel to be used in the surrounding unit forming step so as to prevent the first panel and the second panel from deforming by pressure by the fastening tools.

26. The gas discharge panel production method of Claim 25, wherein

the anti-deformation member and the barrier ribs are made of the same material.

27. The gas discharge panel production method of Claim 25, wherein

the anti-deformation member is formed so as to prevent the sealing material from flowing into an inner area of the surrounding unit.

28. The gas discharge panel production method of Claim 25, wherein

the anti-deformation member and the barrier ribs have the same height.

29. The gas discharge panel production method of Claim 1, wherein

in the sealing step, the surrounding unit is sealed while an anti-displacement means for preventing a relative displacement of the first panel and the second panel is disposed on the surrounding unit.

30. The gas discharge panel production method of Claim 1, wherein

an anti-sealing-material-inflow member is disposed at the rim of at least one of the first panel and the second panel to be used in the surrounding unit forming step so as to prevent the sealing material from flowing into an inner area of the

surrounding unit.

31. The gas discharge panel production method of Claim 30, wherein

the sealing material is disposed at outside the anti-sealing-material-inflow member during the surrounding unit forming step.

32. The gas discharge panel production method of one of Claims 1 to 3 and 6 to 20 further comprising:

an adhesive application step for applying an adhesive to top of the barrier ribs on the first panel, the applied adhesive being to bond the top of the barrier ribs to the second panel, and the adhesive application step being performed before the surrounding unit forming step, and

in the sealing step, the top of the barrier ribs and the second panel are bonded together by the applied adhesive as the surrounding unit is sealed by the sealing material.

33. The gas discharge panel production method of Claim 32, wherein

in the sealing step, the pressure adjustment sub-step is started before the sealing material and the adhesive harden.



34. The gas discharge panel production method of Claim 32, wherein

in the sealing step, the top of the barrier ribs and the second panel are bonded together by softening and then hardening the applied adhesive as the surrounding unit is sealed by softening and then hardening the sealing material.

35. The gas discharge panel production method of Claim 34, wherein

the sealing material and the adhesive are made of low-melting glasses, and

softening point of the adhesive is lower than softening point of the sealing material.

36. A gas discharge panel production method comprising:

a surrounding unit forming step for forming a surrounding unit by putting a first panel and a second panel together, wherein barrier ribs for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are put together to face each other with the barrier ribs in between;

a sealing step for sealing the surrounding unit with a sealing material inserted between the first panel and the second panel at the rim; and

a bonding step for bonding top of the barrier ribs and

the second panel together by radiating an energy onto the top of the barrier ribs to soften the top of the barrier ribs.

37. The gas discharge panel production method of Claim 36, wherein

the top of the barrier ribs formed in the surrounding unit forming step is made of a material which has a property of absorbing the energy radiated in the bonding step.

38. The gas discharge panel production method of Claim 36, wherein

the top of the barrier ribs formed in the surrounding unit forming step is made of a black material.

39. A gas discharge panel production method comprising:

an adhesive application step for applying an adhesive on top of barrier ribs which partition light-emitting cells, the barrier ribs being formed on a first panel;

a surrounding unit forming step for forming a surrounding unit by putting the first panel and a second panel together to face each other with the adhesive on top of the barrier ribs in between;

a sealing step for sealing the surrounding unit with a sealing material inserted between the first panel and the second panel at the rim; and

a bonding step for bonding top of the barrier ribs and the second panel together by radiating an energy onto the adhesive on top of the barrier ribs to soften the adhesive.

40. The gas discharge panel production method of Claim 39, wherein

the adhesive applied in the adhesive application step is made of a material which has a property of absorbing the energy radiated in the bonding step.

41. The gas discharge panel production method of Claim 39, wherein

the adhesive applied in the adhesive application step is made of a black material.

42. The gas discharge panel production method of one of Claims 36 to 41, wherein

whichever comes first out of the sealing step and the bonding step includes, or both of the sealing step and the bonding step include:

a pressure adjustment sub-step for adjusting pressure so that pressure inside the surrounding unit is lower than pressure outside the surrounding unit.

43. The gas discharge panel production method of one of Claims

36 to 41, wherein

in the sealing step, the barrier ribs are observed in terms of shape, and condition for radiating the energy is controlled based on results of the observance.

44. A gas discharge panel production method comprising:

an adhesive application step for applying an adhesive on top of barrier ribs which partition light-emitting cells, the barrier ribs being formed on a first panel;

a surrounding unit forming step for forming a surrounding unit by putting the first panel and a second panel together to face each other with the adhesive on top of the barrier ribs in between; and

a bonding step for bonding top of the barrier ribs and the second panel together by heating the second panel to soften the adhesive.

45. A gas discharge panel production method comprising:

a surrounding unit forming step for forming a surrounding unit by putting a first panel and a second panel together, wherein barrier ribs for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are put together to face each other with the barrier ribs in between;

a sealing step for sealing the surrounding unit with

a sealing material inserted between the first panel and the second panel at the rim; and

a bonding step for bonding top of the barrier ribs and the second panel together by heating the second panel to soften the top of the barrier ribs.

46. A gas discharge panel production method including a sealing-off step for sealing off an exhaust pipe attached to a surrounding unit by melting the exhaust pipe, the surrounding unit including a pair of panels disposed to face each other, the gas discharge panel production method comprising:

a first step for disposing a heating element at a location a predetermined distance from the exhaust pipe; and

a second step for allowing the heating element to heat the exhaust pipe.

47. The gas discharge panel production method of Claim 46, wherein

in the first step, the heating element is disposed at a location a predetermined distance from the exhaust pipe with a restriction member in between.

48. An exhaust pipe sealing off apparatus for melting and sealing off an exhaust pipe attached to a surrounding unit, the surrounding unit including a pair of panels disposed to face

each other, the exhaust pipe sealing off apparatus comprising:

a heating element holding means for holding a heating element at a location a predetermined distance from the exhaust pipe, the heating element holding means being attached to the exhaust pipe.

49. An exhaust pipe sealing off apparatus for melting and sealing off an exhaust pipe attached to a surrounding unit, the surrounding unit including a pair of panels disposed to face each other, the exhaust pipe sealing off apparatus comprising:

a heating unit including a cylinder-shaped body inside of which a heating element is held, the cylinder-shaped body having an inner diameter larger than an outer diameter of the exhaust pipe; and

a restriction member for restricting position of the heating unit so that the heating unit is disposed around the exhaust pipe at distance from the exhaust pipe.

50. The exhaust pipe sealing off apparatus of Claim 49, wherein

the restriction member can be divided into two parts by a plane passing center axis of the exhaust pipe.

51. The exhaust pipe sealing off apparatus of Claim 49 or Claim 50, wherein

the restriction member is disposed at two locations or more along the exhaust pipe between the heating unit and the exhaust pipe.

52. The exhaust pipe sealing off apparatus of Claim 49, wherein

the heating unit further includes an insulation, and

the heating element is shaped as a coil and is wound inside the insulation.

53. A gas discharge panel produced with a production method defined in one of Claims 1 to 3 and 6 to 20.

54. A gas discharge panel including a first panel and a second panel, wherein barrier ribs for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are bonded together at the rim, the first panel and the second panel facing each other with the barrier ribs in between, wherein

top of the barrier ribs and the second panel are bonded together by melting a material of the barrier ribs.

55. A gas discharge panel bonding apparatus comprising:

a surrounding unit housing unit for housing a

surrounding unit which is formed by putting a first panel and a second panel together, wherein barrier ribs for partitioning light-emitting cells are formed on a main surface of the first panel, and the first panel and the second panel are put together to face each other with the barrier ribs in between; and

a sealing means for sealing the surrounding unit housed in the surrounding unit housing unit by softening a sealing material inserted between the first panel and the second panel at the rim then hardening the sealing material; and

a pressure adjustment means for adjusting pressure so that pressure inside the surrounding unit is lower than pressure outside the surrounding unit.

56. The gas discharge panel bonding apparatus of Claim 55, wherein

the sealing material is a low-melting glass, and

the sealing means includes a heating element which heats and softens the sealing material.

57. The gas discharge panel bonding apparatus of Claim 56, wherein

an adhesive made of a low-melting glass is applied to top of the barrier ribs of the first panel housed in the surrounding unit housing unit, and

the heating element heats and softens the adhesive as



well as the sealing material.

58. The gas discharge panel bonding apparatus of Claim 55, wherein

an adhesive is applied to top of the barrier ribs of the first panel housed in the surrounding unit housing unit, and

the gas discharge panel bonding apparatus further comprises:

a bonding means for bonding top of the barrier ribs and the second panel together by softening and then hardening the adhesive.

59. The gas discharge panel bonding apparatus of Claim 58, wherein

the adhesive applied to the top of the barrier ribs is made of a low-melting glass, and

the bonding means includes a laser beam radiating apparatus which radiates a laser beam.



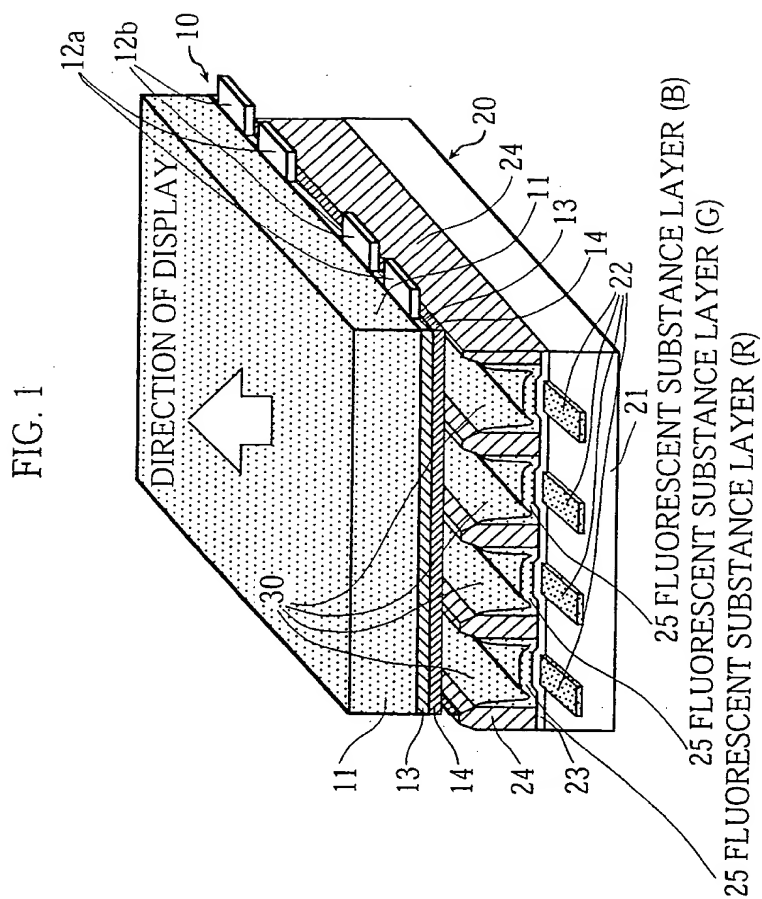




FIG. 2

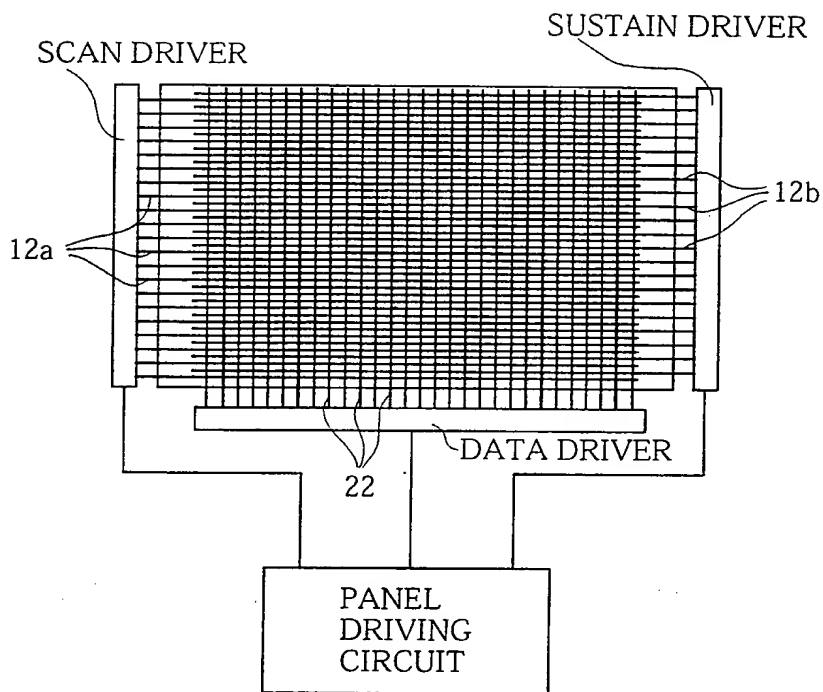


FIG. 3

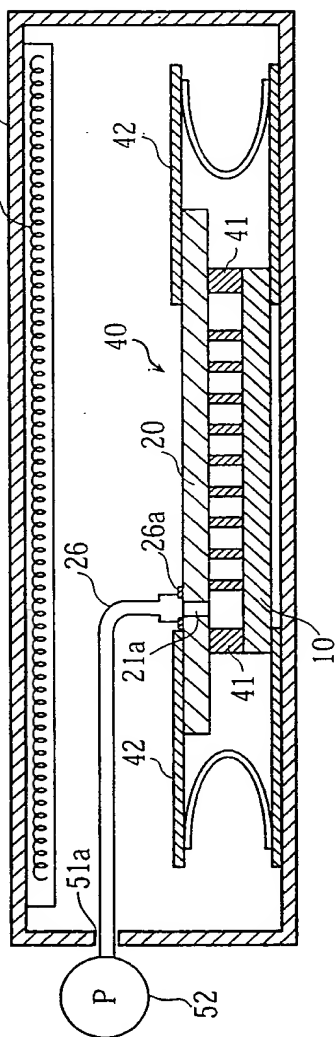


FIG. 4

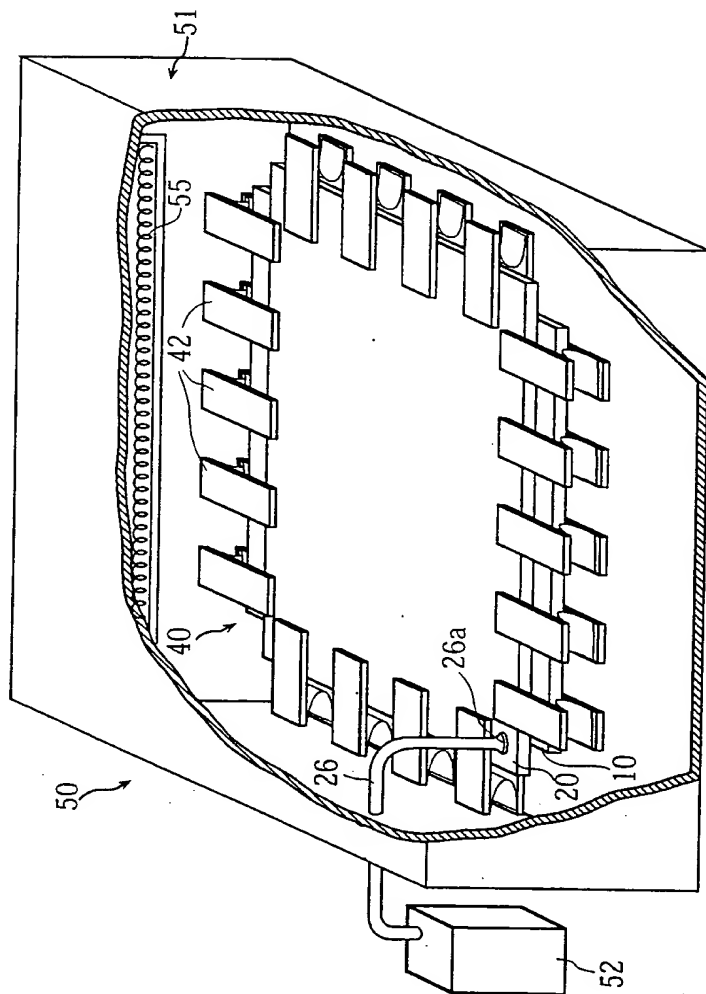


FIG. 5A

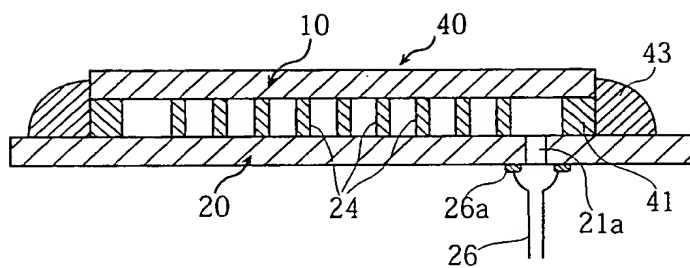


FIG. 5B

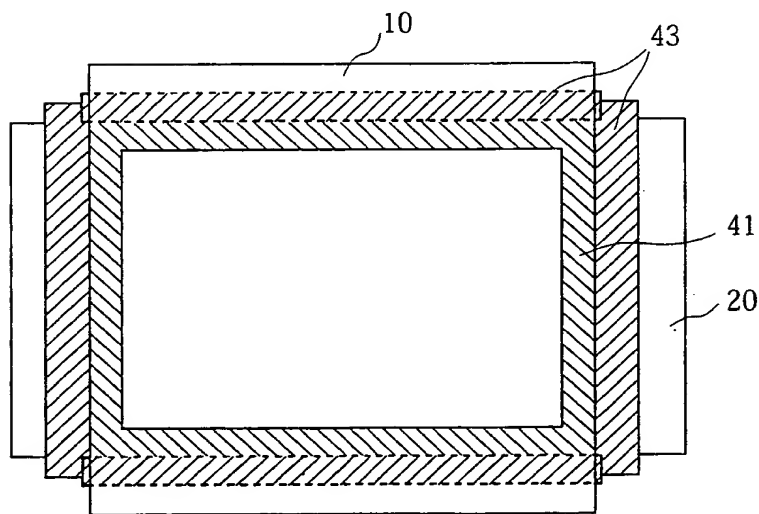




FIG. 6A

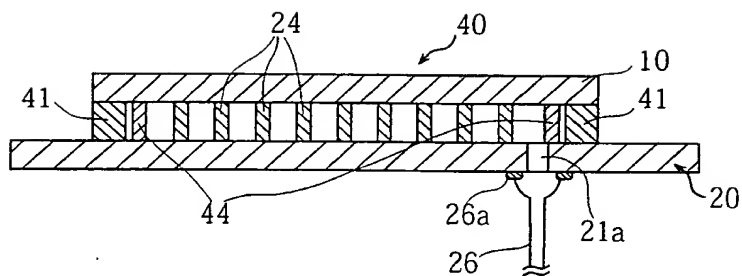


FIG. 6B

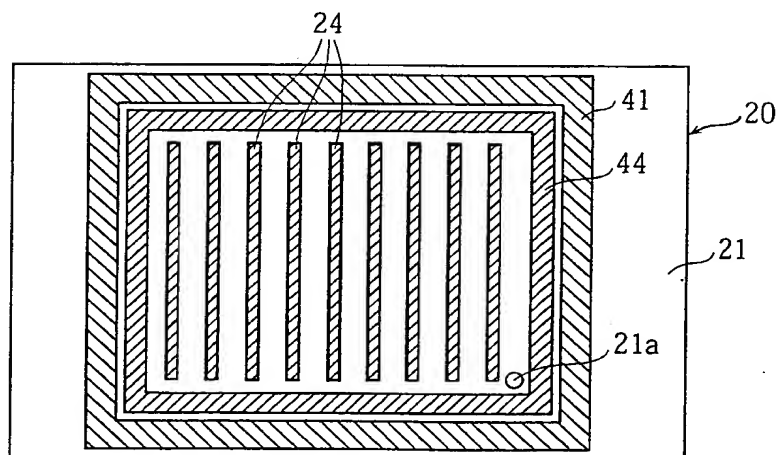


FIG. 7

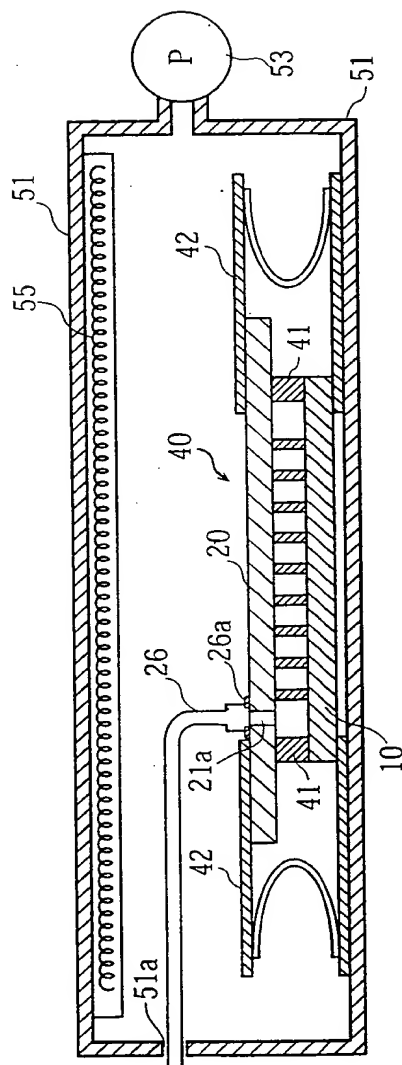


FIG. 8

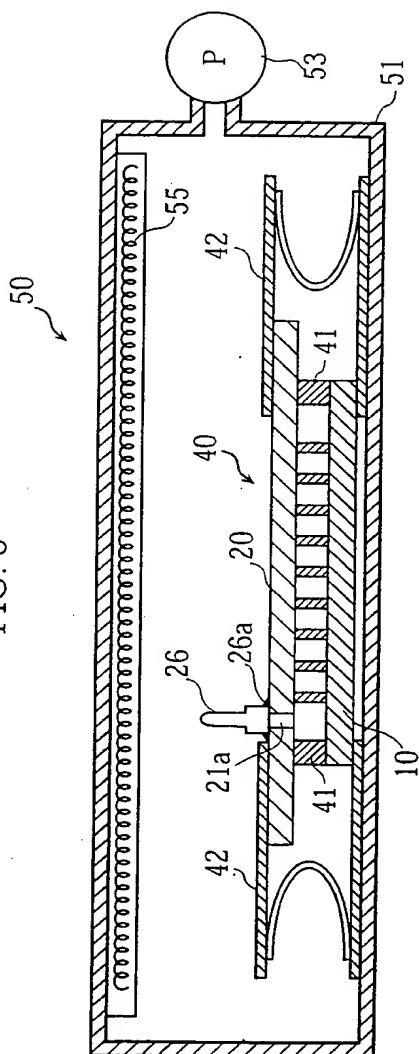


FIG. 9A

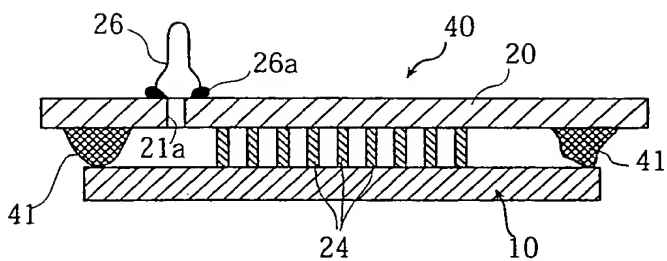


FIG. 9B

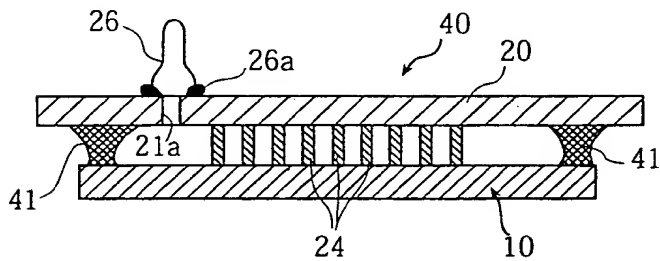


FIG. 10

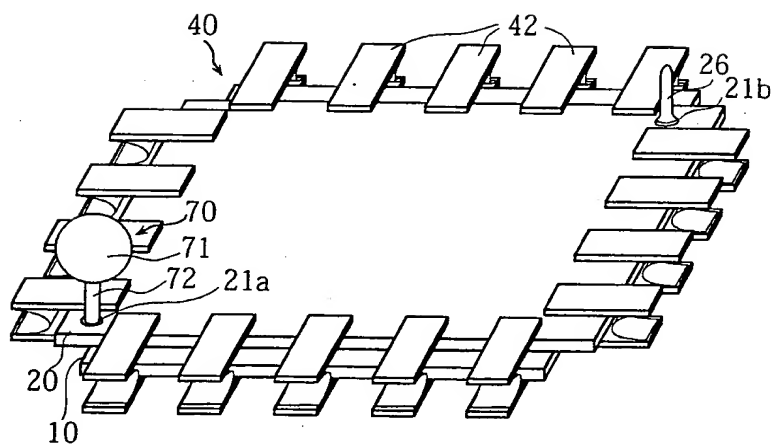


FIG. 11A

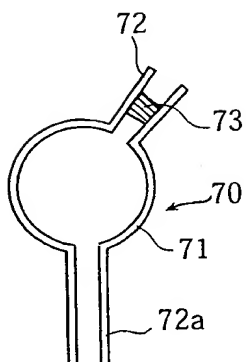


FIG. 11B

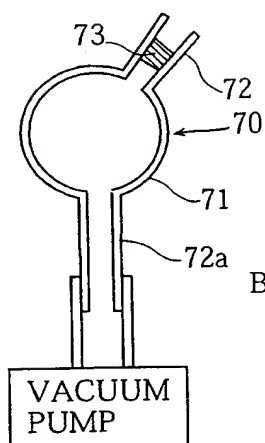


FIG. 11C

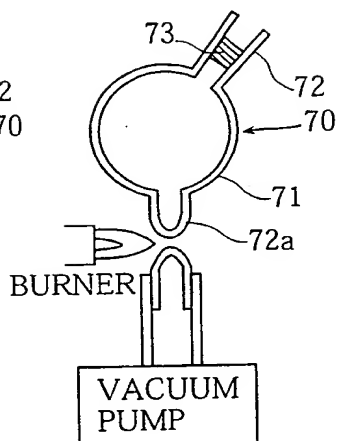


FIG. 12

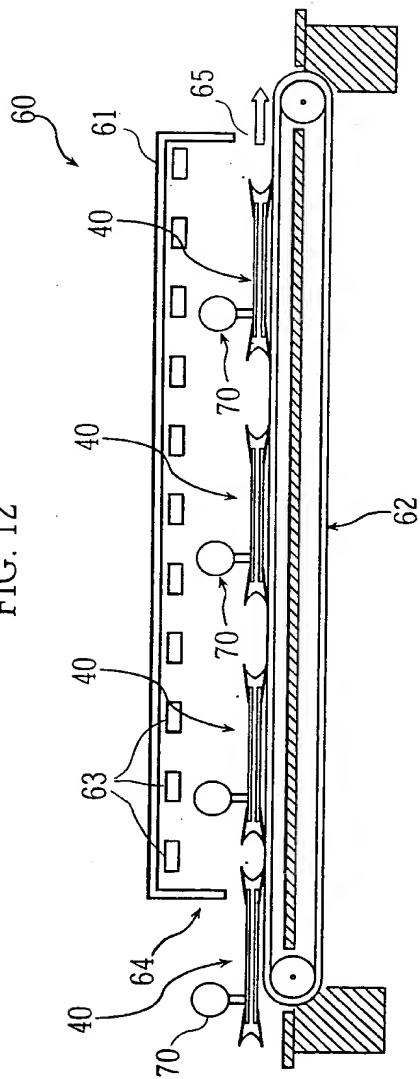


FIG. 13A

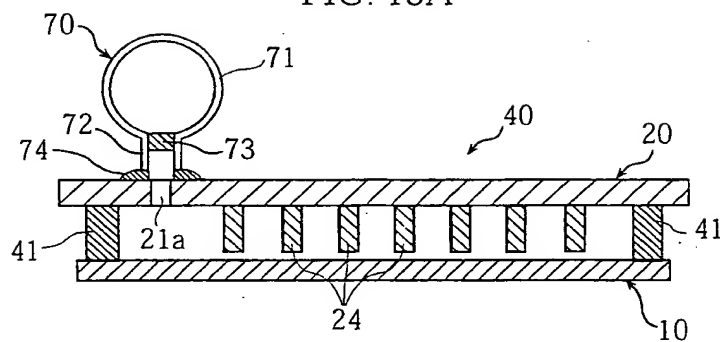


FIG. 13B

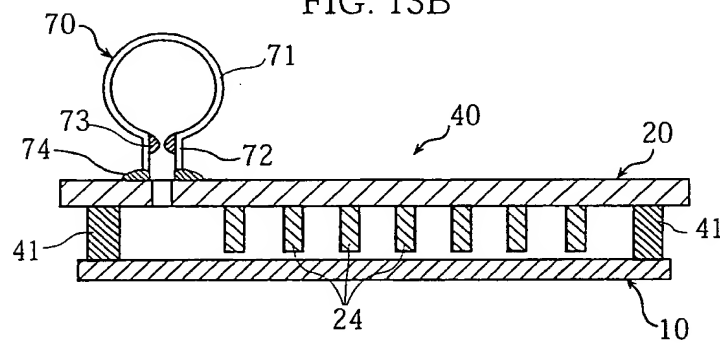


FIG. 13C

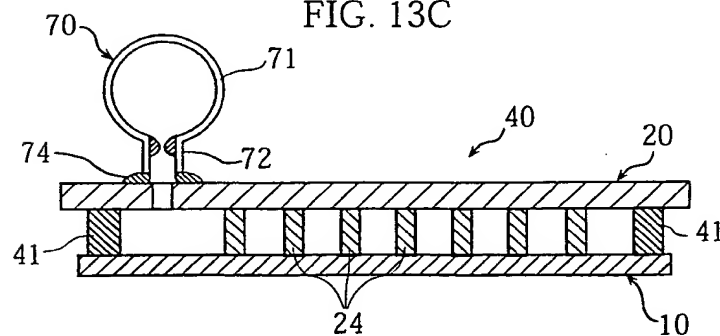
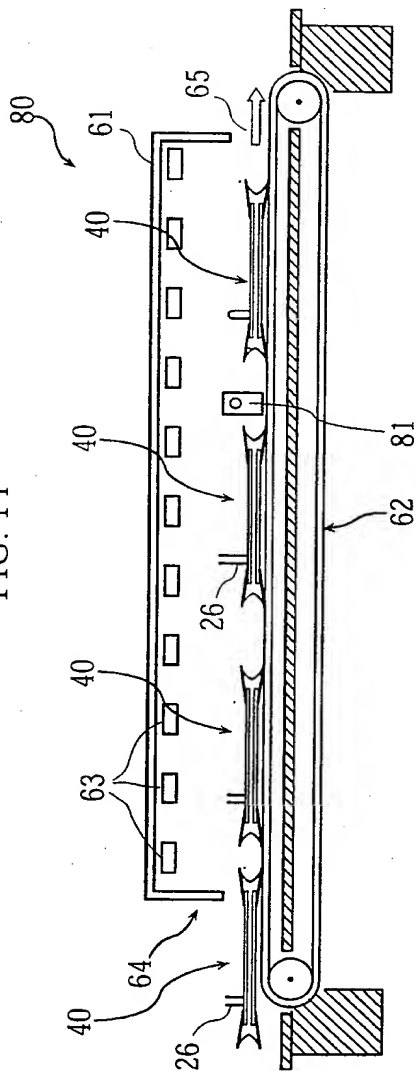




FIG. 14



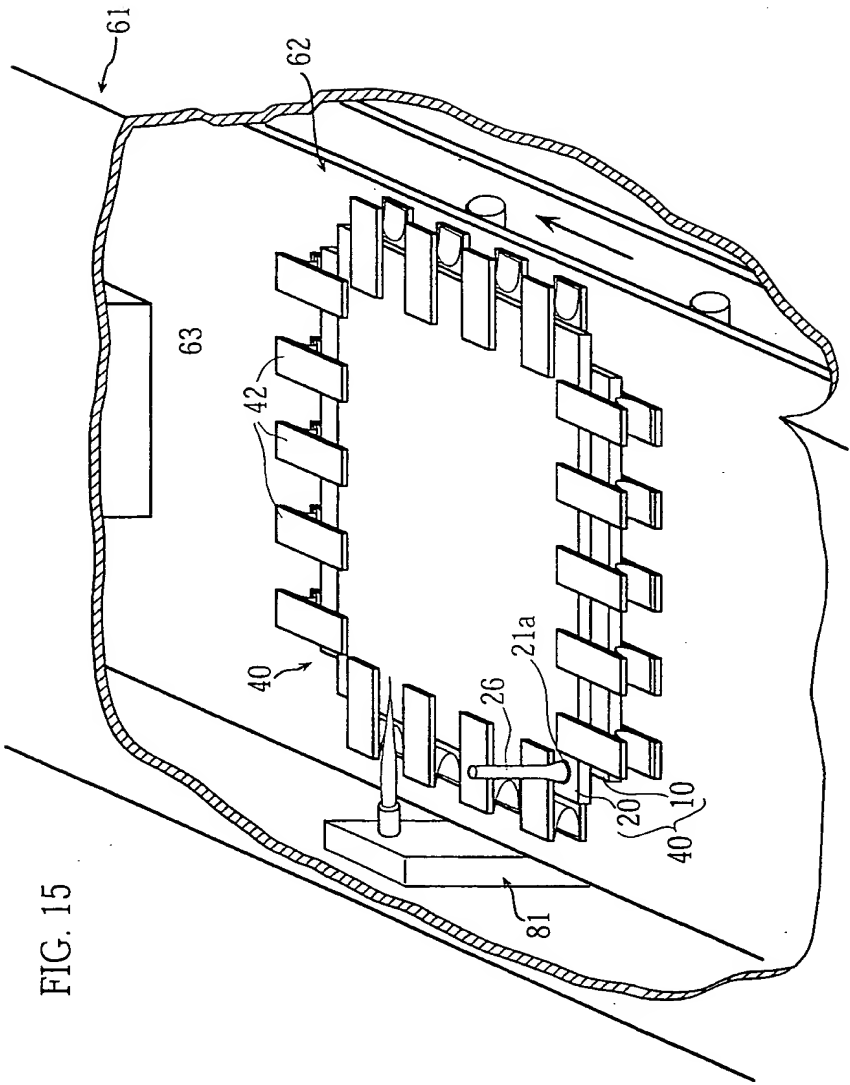


FIG. 15

FIG. 16A

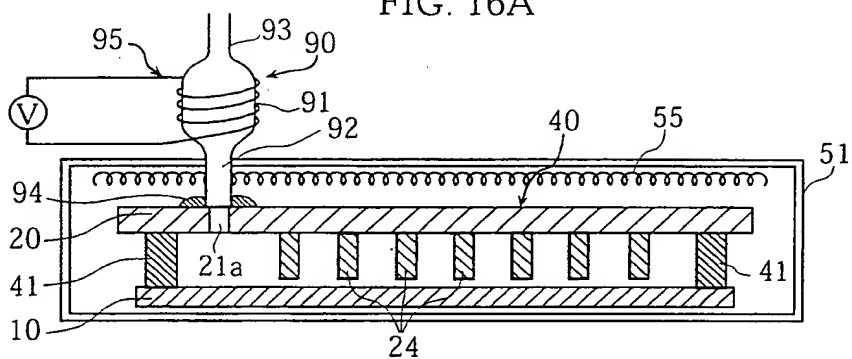


FIG. 16B

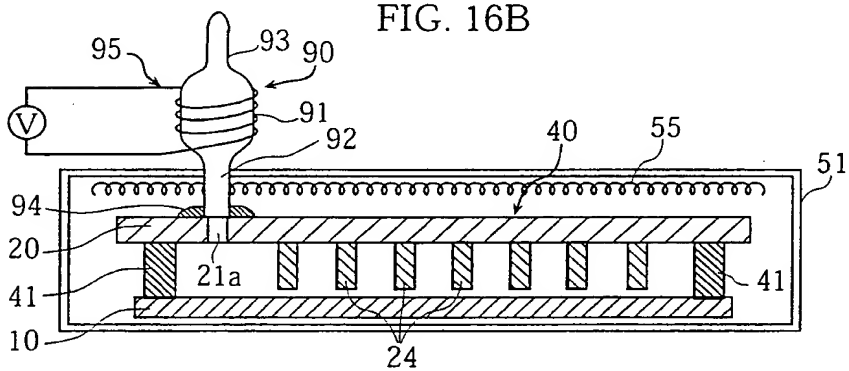


FIG. 16C

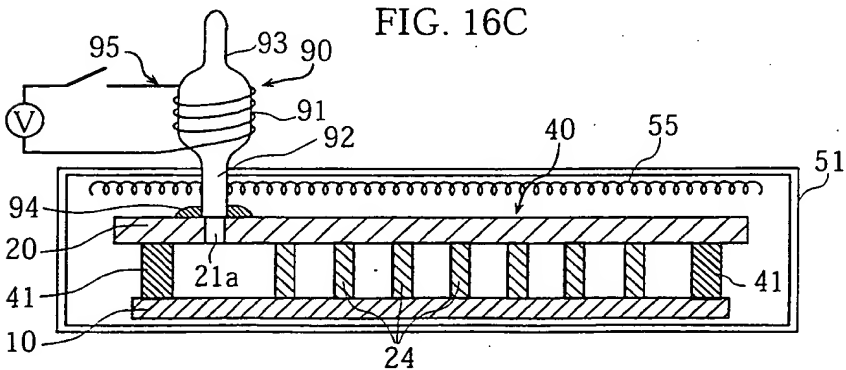


FIG. 17

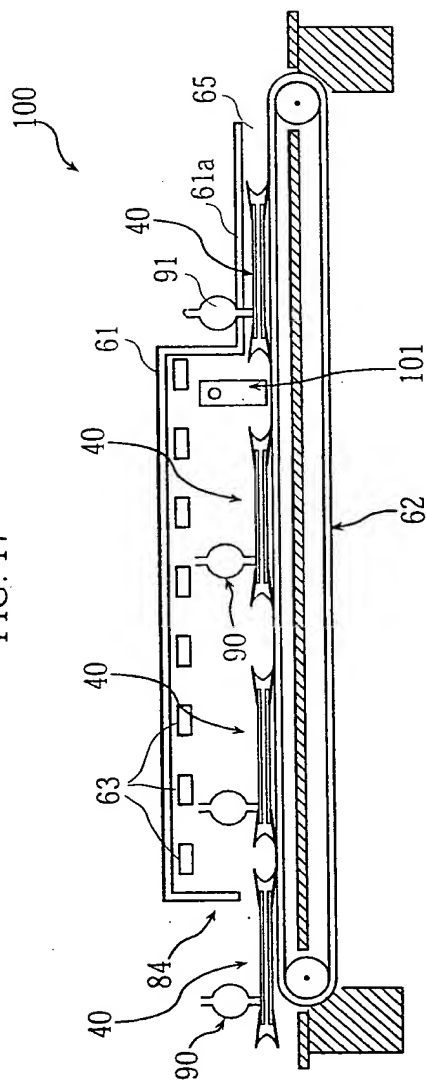


FIG. 18

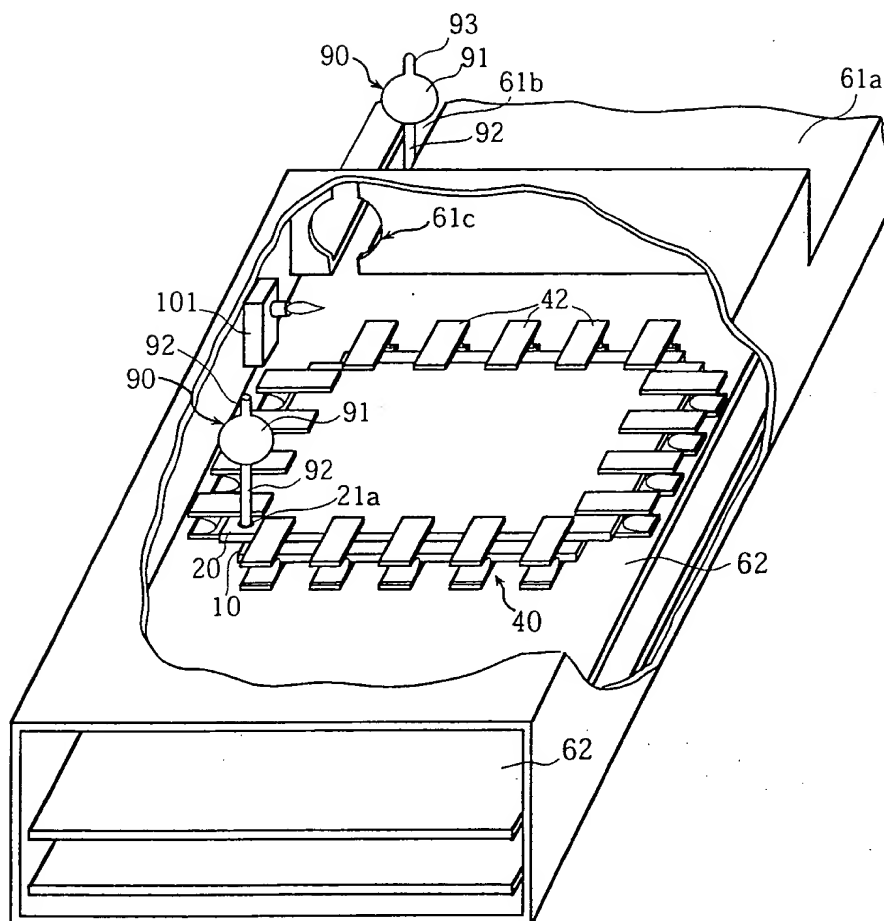


FIG. 19

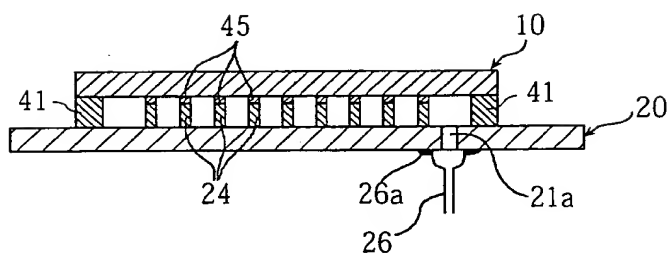


FIG. 20A

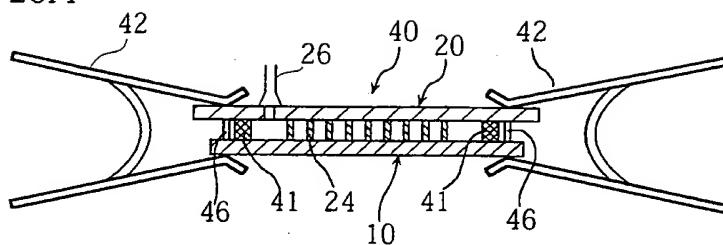


FIG. 20B

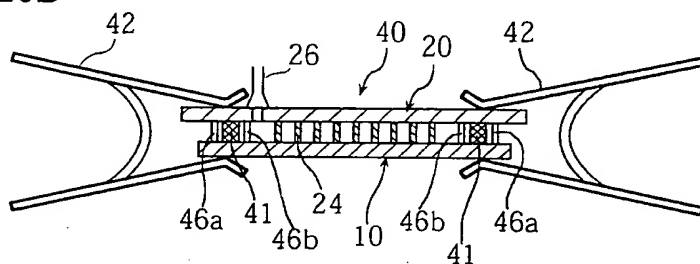


FIG. 20C

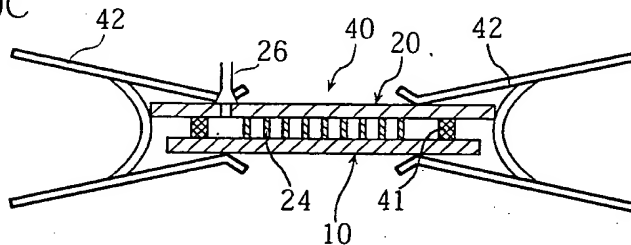


FIG. 20D

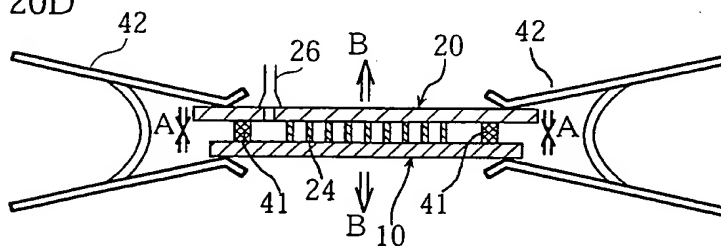


FIG. 21A

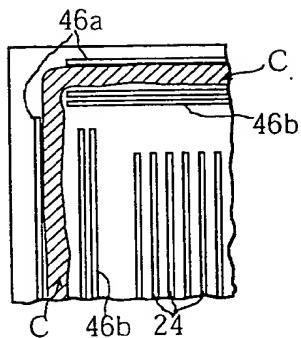


FIG. 21B

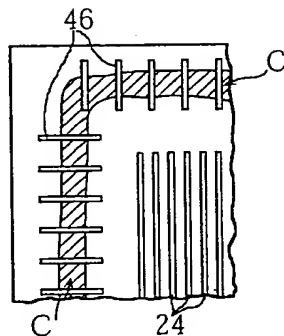


FIG. 21C

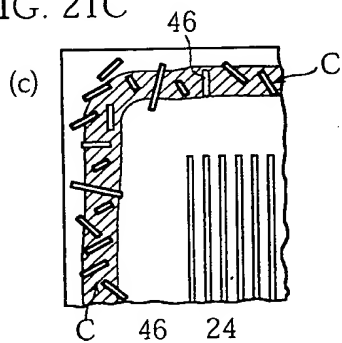


FIG. 21D

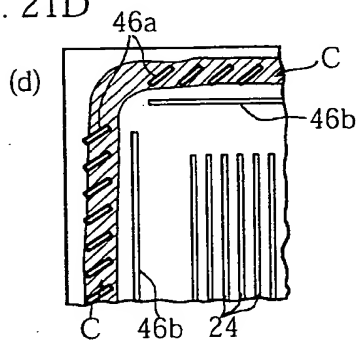


FIG. 21E

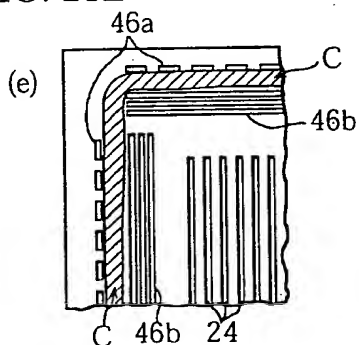
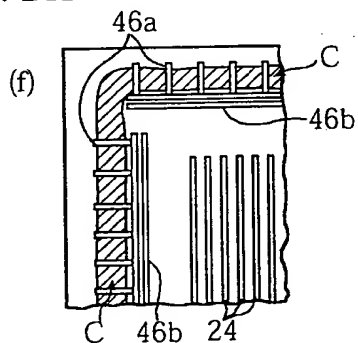


FIG. 21F





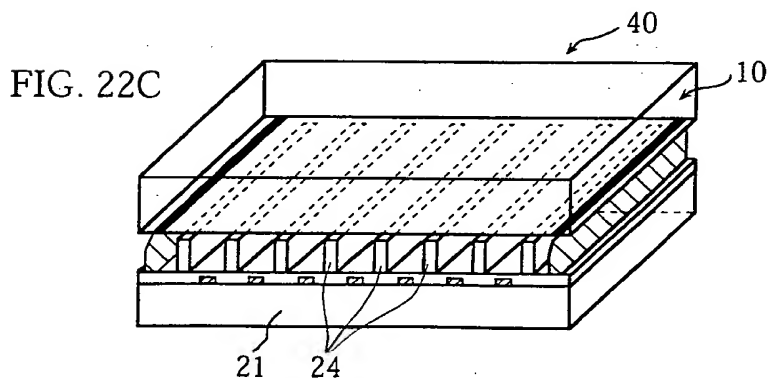
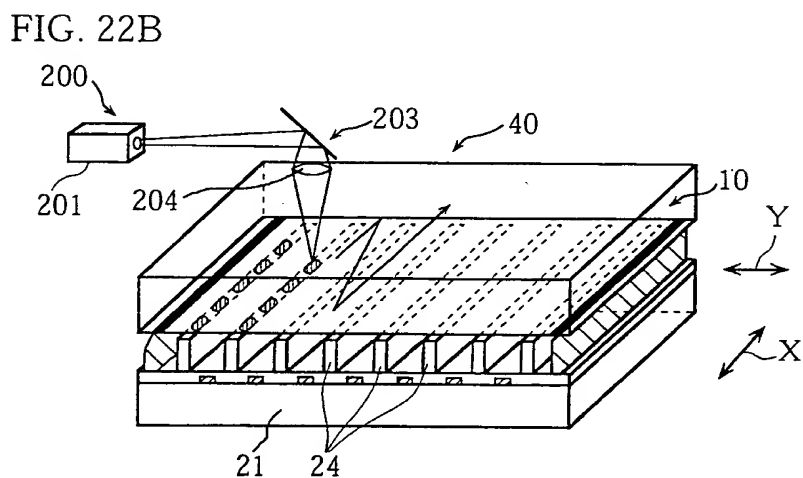
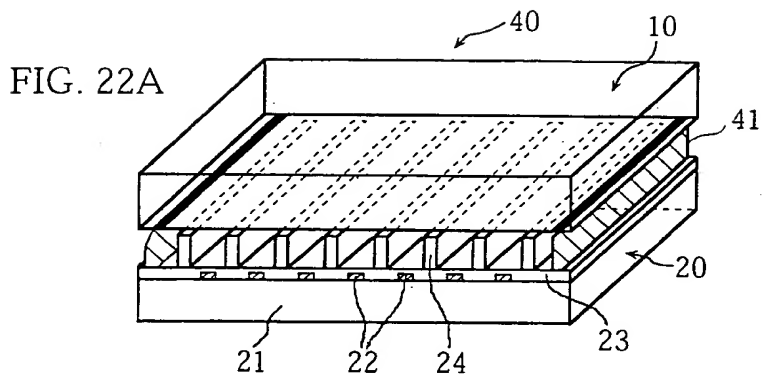


FIG. 23

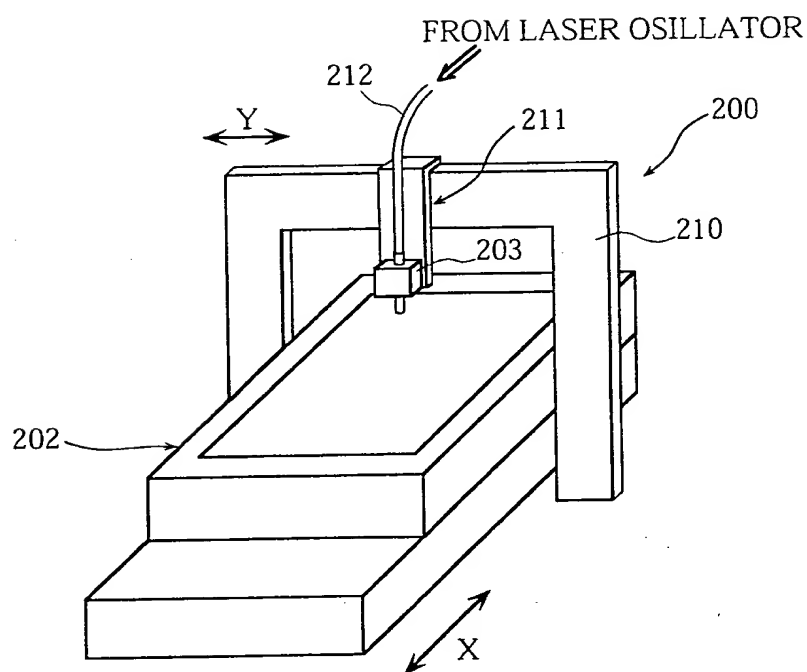


FIG. 24

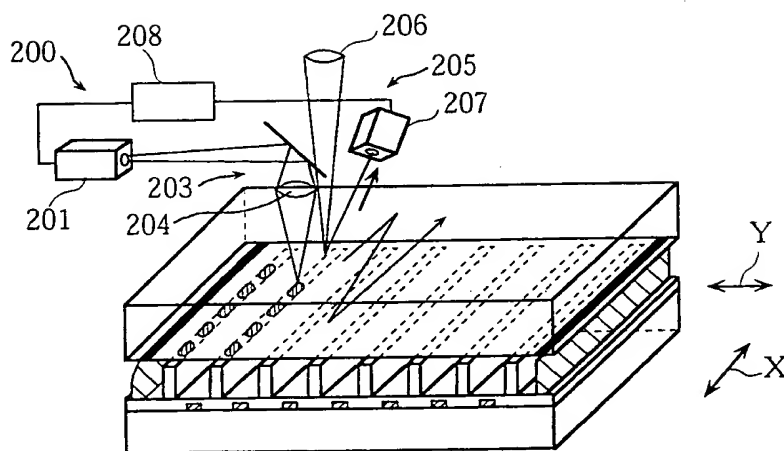


FIG. 25

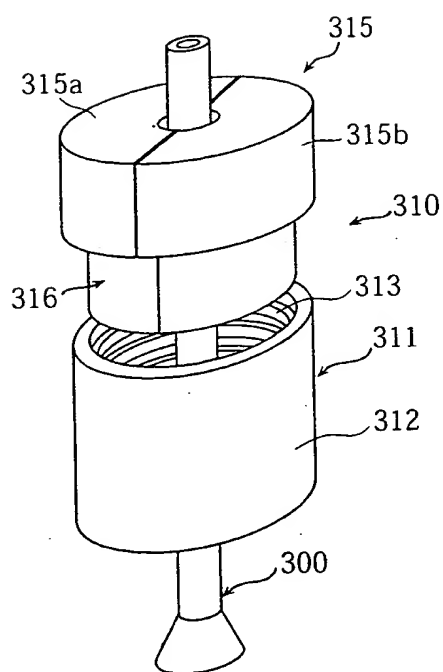


FIG. 26

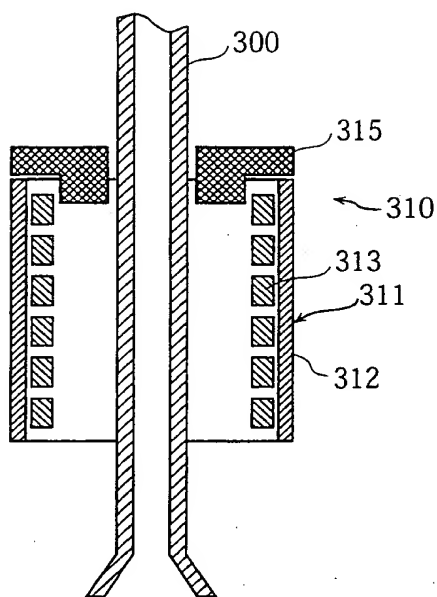


FIG. 27

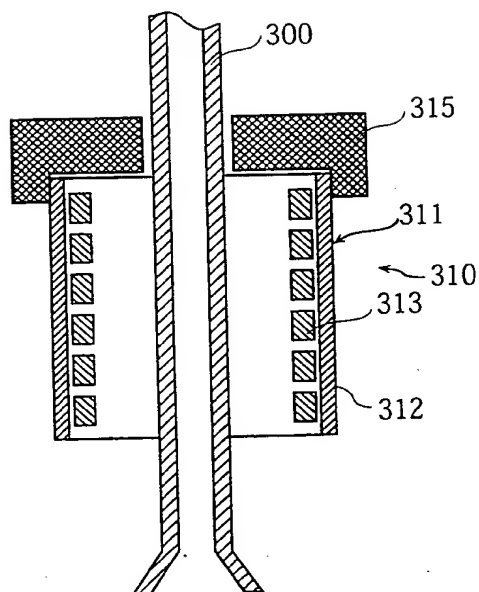


FIG. 28

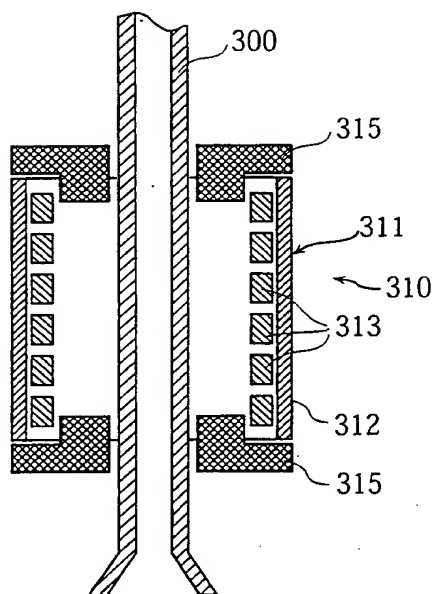


FIG. 29

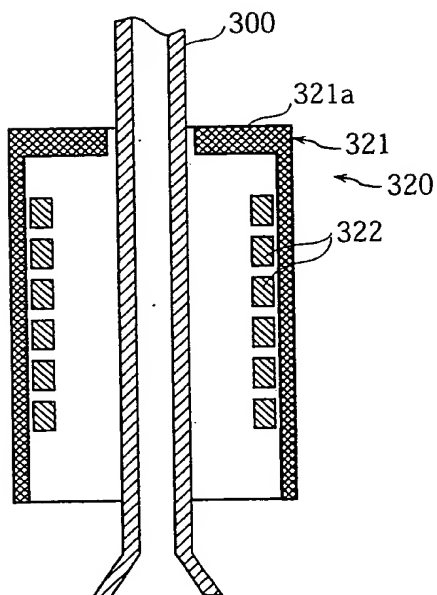


FIG. 30

